

# Recent Advances in Engineered Surfaces, Nanostructured Coatings & Novel Deposition Techniques

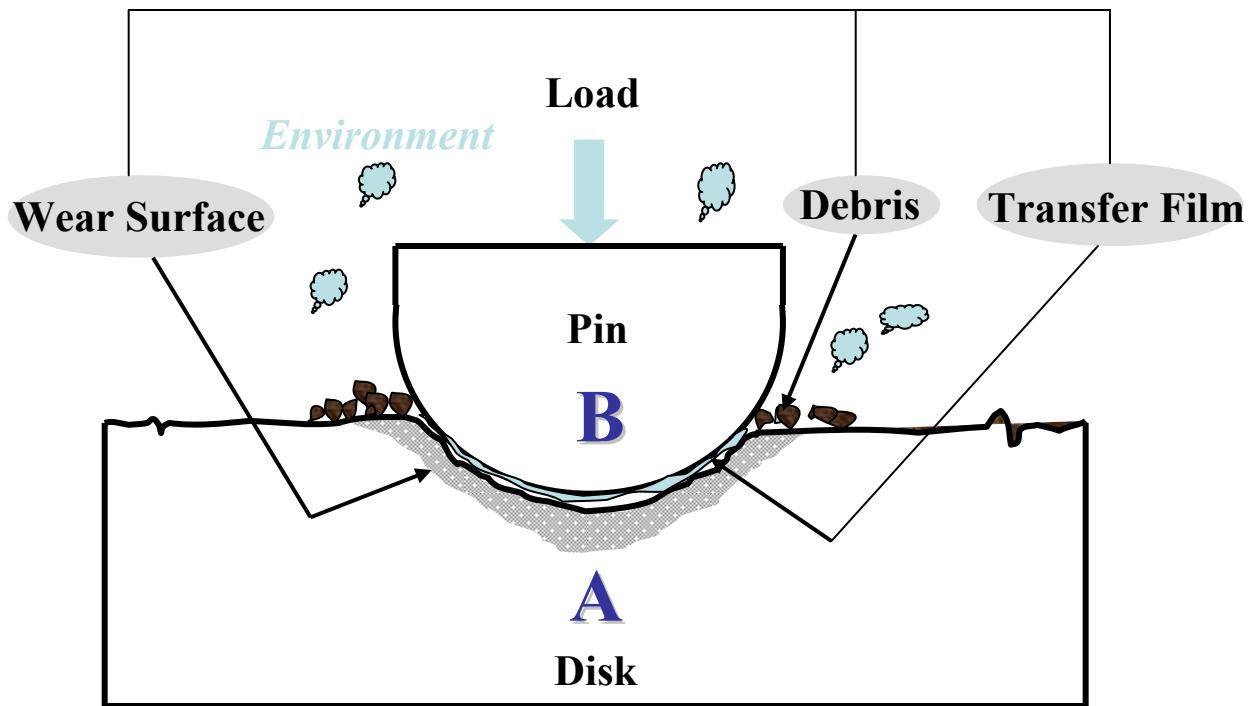
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*Next Generation Materials for Defense 2007  
Institute for Defense and Government Advancement  
March 29, 2007, Arlington, VA*



# Tribology is a systems property

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**Mechanical Interlocking  
(Surface Morphology)**



**Adhesion**



**Debris Entrapment**



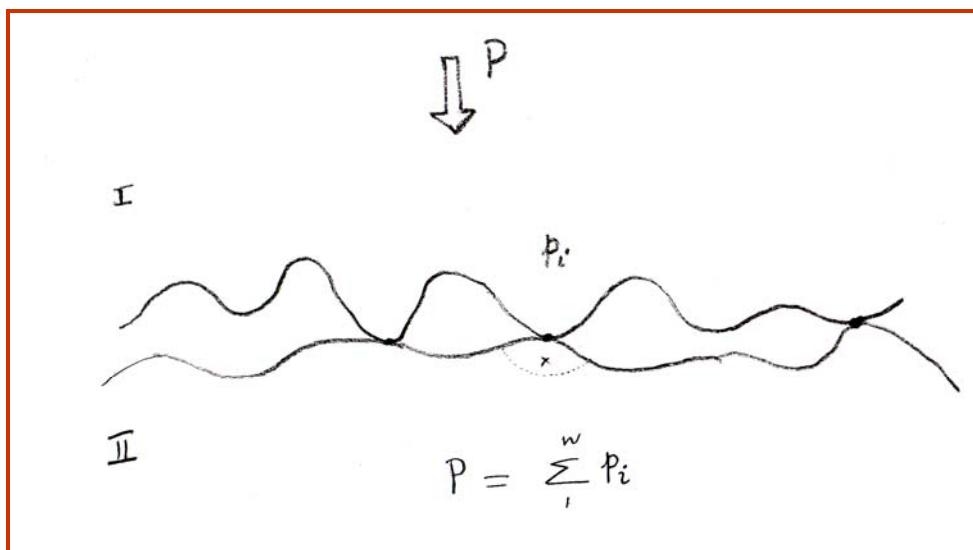
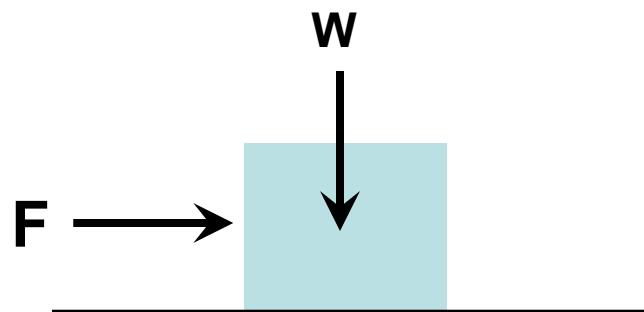
# Recognize the limitations of the laws of friction

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## Guillaume Amontons (1663-1705)

*Unaware of da Vinci's (1452-1519) recorded observations*

- Friction force is proportional to normal force
- Magnitude of friction force does not depend on the apparent area of contact



- Engineering surfaces are not atomically flat
- Contact will be at asperity level
- Surface composition typically differs from the bulk
- Sliding contact results:
  - Plastic deformation
  - Diffusion
  - Fracture initiation
  - Tribochimistry and Environmental reactions



# Tribomaterials

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## Major Examples

- Materials for Bearings
- Friction Materials
- Abrasion-Resistant Materials
- Metal-Cutting Tools
- Biomedical Materials

### \*\*\*Friction and Wear\*\*\*

Materials for Tribological Applications must also have a  
*“Precise Balance of Physical and Mechanical Properties”*

*(thermal expansion, damping capacity, conformability, strength, stiffness and fatigue life)*

It is practically impossible to meet these diverse requirements with single phase materials. Materials strategies include:

- Composite Materials
- Engineered Surfaces
- Coatings



# Outline

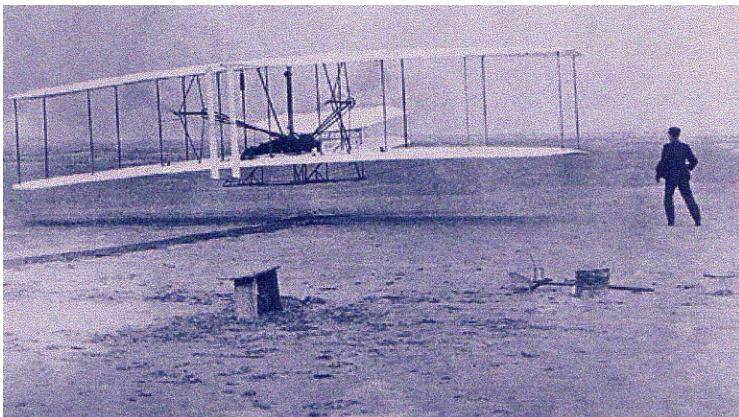
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- Historic Example
  - Development of Wright Brothers' Engine
- Materials by Design
  - Metal-Matrix Composites (MMCs)
  - Polymer-Derived Ceramics (PDCs)
- Solid Lubricants, Thin Films and Coatings
  - Transition metal dichalcogenides ( $\text{MoS}_2$ ,  $\text{WS}_2$ )
  - Diamond-Like Carbon
- Tribological Issues in MEMS
- Atomic Layer Deposition



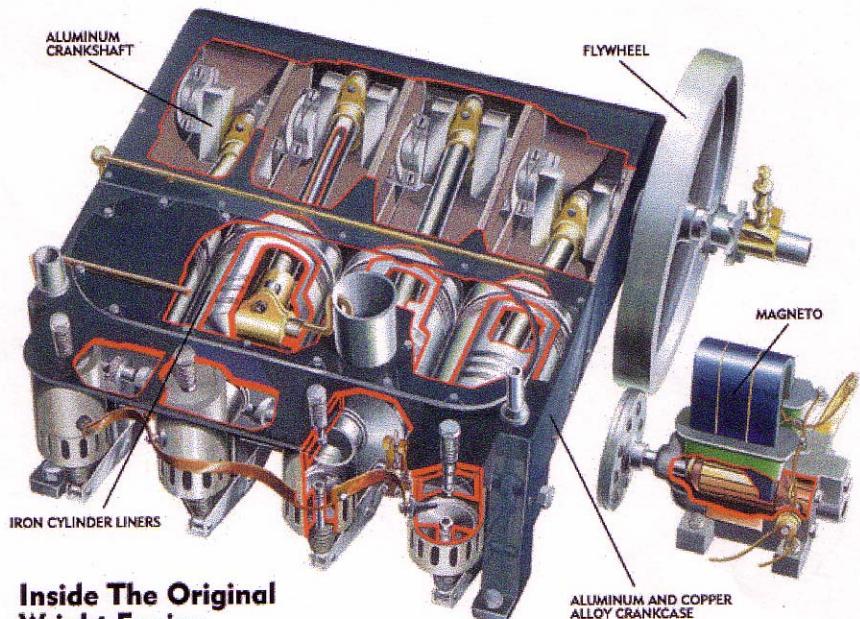
# Historical Perspective: The Saga of Wright Brothers' Engine Development

1903



Mr. Charles Taylor (Mechanic)  
Considered replacing CI with Al-Cu

- The Brothers needed an Engine with 8 HP weighing <180 lbs



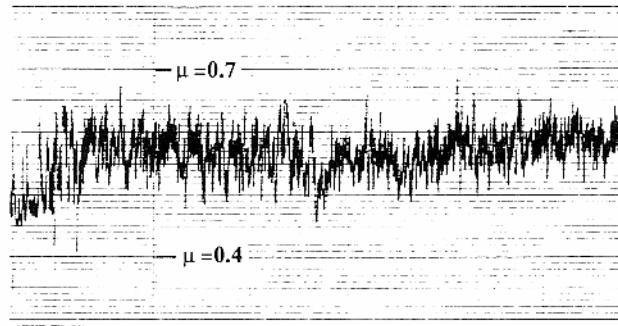
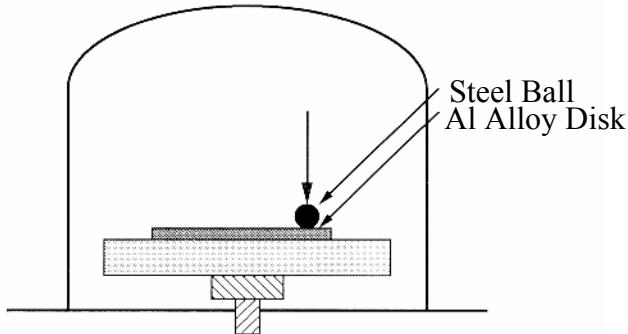
Inside The Original Wright Engine

- 16 HP-12HP 178 lbs
- The Brothers used the extra weight allowance to strengthen the wings and frame
- But Al has a tendency for seizure and galling in the absence of complete fluid film lubrication

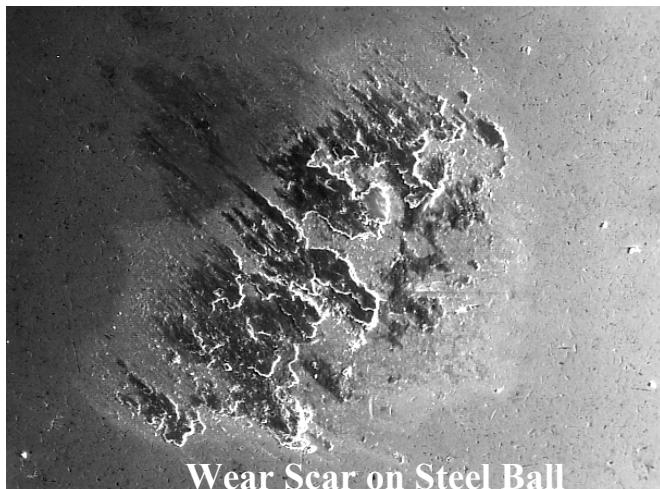


# Aluminum has poor resistance to seizure and galling

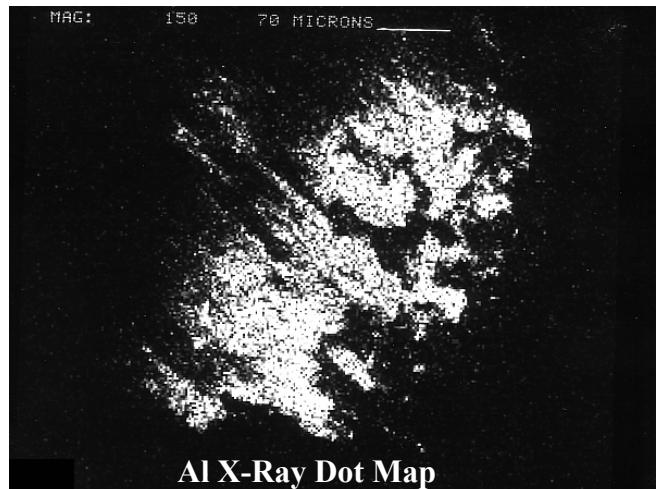
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- In the absence of external fluid lubrication, aluminum has a tendency to adhere to the hard counterface, creating an interface of weak nature. Note the transfer of aluminum to the steel counterface during a ball-on-disk test. Friction is of stick-slip type with a coefficient of 0.5 to 0.6.



Wear Scar on Steel Ball



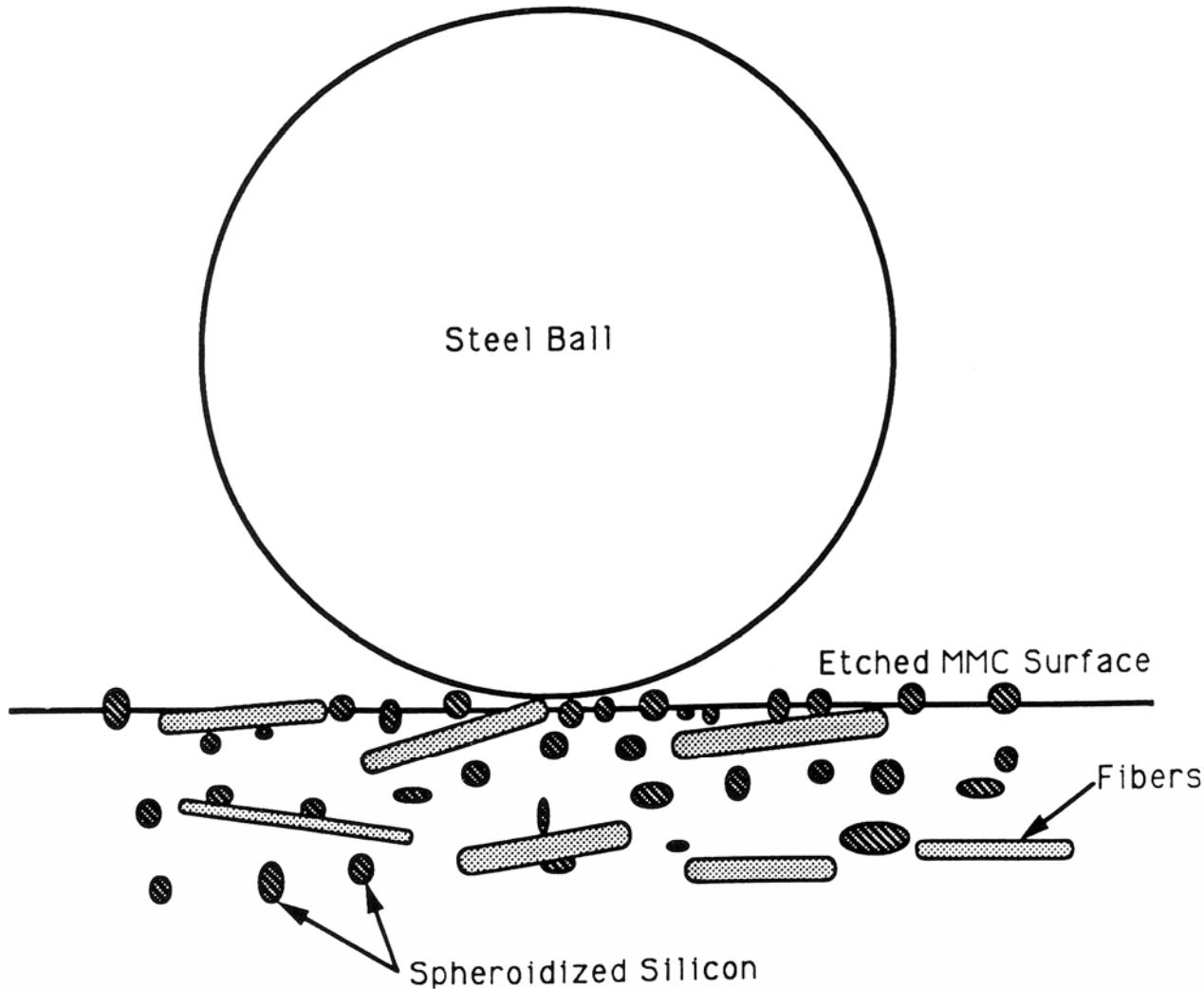
Al X-Ray Dot Map

Mr Taylor's solution: Use thin cast iron liners in Al-Cu crankcase



# Engineered Surfaces for Precise Balance of Tribological and Physical Properties

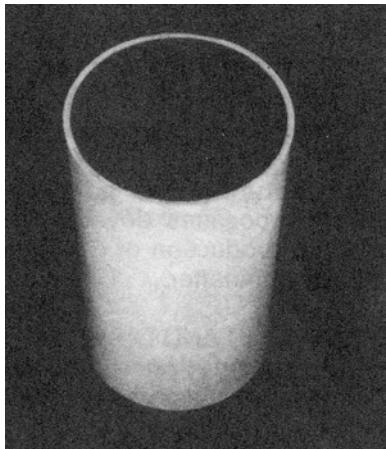
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# Integrally Cast MMC Cylinder: Honda Corporation

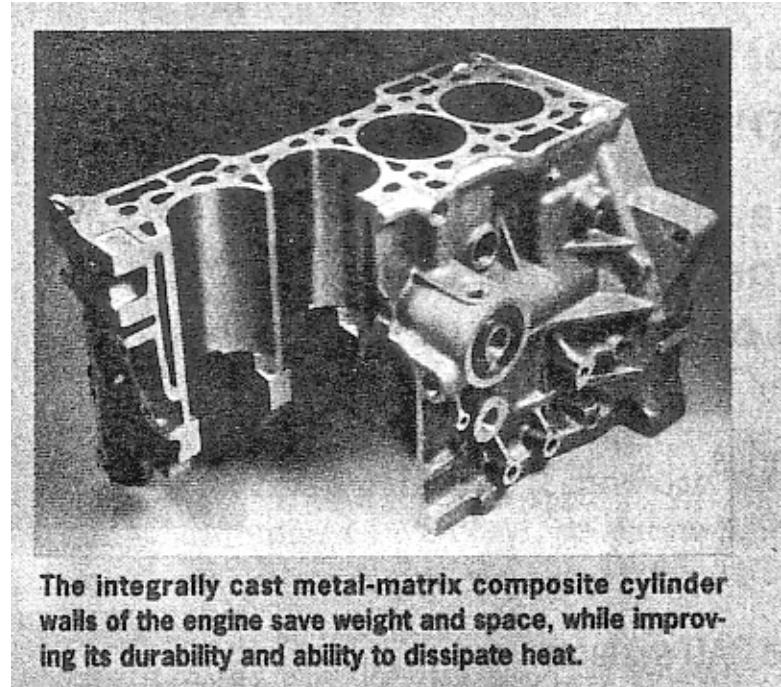
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**Preform**

A porous hybrid material made out of  
Short alumina and Carbon fibers

- Ceramic “preform” production
- Pressure casting process
- Honing



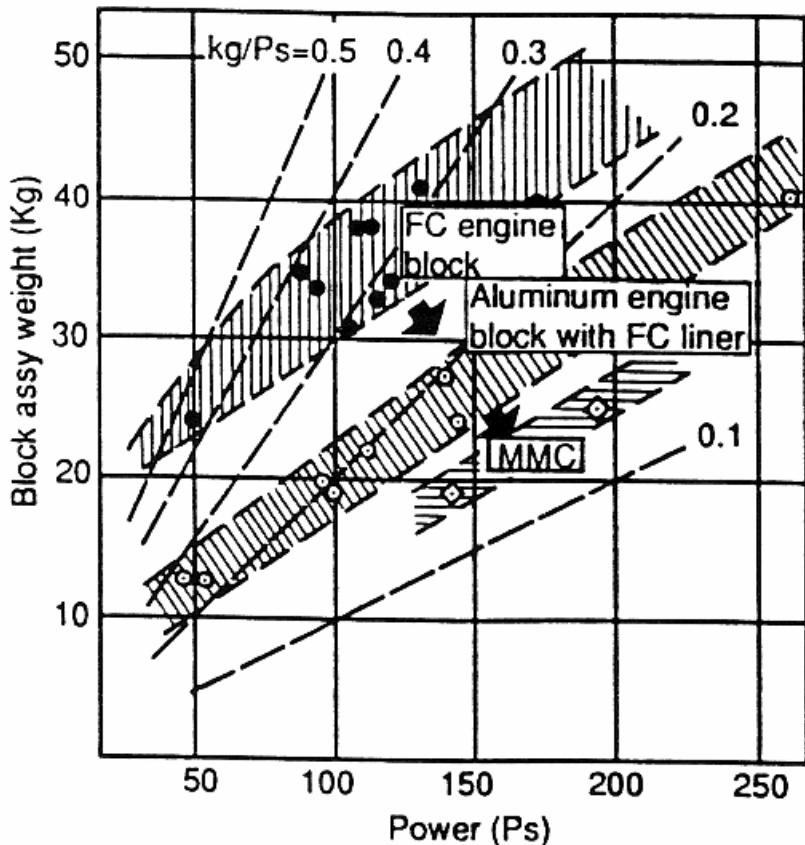
**The integrally cast metal-matrix composite cylinder walls of the engine save weight and space, while improving its durability and ability to dissipate heat.**

**M. Ebisawa et. al, “The Production Process for MMC Engine Block”, SAE 910835**



# Relationship between Power and engine block weight

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The new engine block features higher performance, further compactness and weight reduction compared to cast-iron engine blocks and those made out of Al alloy with cast-iron liners

M. Ebisawa et. al, "The Production Process for MMC Engine Block", SAE 910835



# Commercial Applications of Al MMCs

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Manufacturer	Component & Composite
Duralcan, Martin Marietta, Lanxide	Pistons, Al/SiC <sub>p</sub>
<b>Duralcan, Lanxide</b>	Brake rotors, calipers, liners, Al/SiC <sub>p</sub>
GKN, Duralcan	Propeller shaft, Al/SiC <sub>p</sub>
<b>Nissan</b>	<b>Connecting rod, Al/SiC<sub>w</sub></b>
Dow Chemical	Sprockets, pulleys, covers, Mg/SiC <sub>p</sub>
<b>Toyota</b>	Piston rings, Al/Al <sub>2</sub> O <sub>3</sub> (saffil) & Al/Boria <sub>w</sub>
Dupont, Chrysler	Connecting rods, Al/Al <sub>2</sub> O <sub>3</sub>
Hitachi	Current collectors, Cu/graphite
Associated Engineering, Inc.	Cylinders, pistons, Al/graphite
Martin Marietta	Pistons, connecting rods, Al/TiC <sub>p</sub>
Zollner	Pistons, Al/fiberfrax
<b>Honda</b>	<b>Engine blocks, Al/Al<sub>2</sub>O<sub>3</sub> – C<sub>f</sub></b>
Lotus Elise, Volkswagen	Brake rotors, Al/SiC <sub>p</sub>
<b>Chrysler</b>	Brake rotors, Al/SiC <sub>p</sub>
<b>GM</b>	Rear brake drum for EV-1, driveshaft, engine cradle, Al/SiC <sub>p</sub>
MC-21, Dia-Compe, Manitou	Bicycle fork brace and disk brake rotors, Al/SiC <sub>p</sub>
3M	Missile fins, aircraft electrical access door, Al/Nextel <sub>f</sub>
Knorr-Bremse; Kobenhavn	Brake disc on ICE bogies, SiC/Al
Alcoa Innometalx	Multichip electronic module, Al/SiC <sub>p</sub>
Lanxide	PCB Heat sinks, Al/SiC <sub>p</sub>
Cercast	Electronic packages, Al/graphite foam
Textron Specialty Materials	PCB heat sinks, Al/B

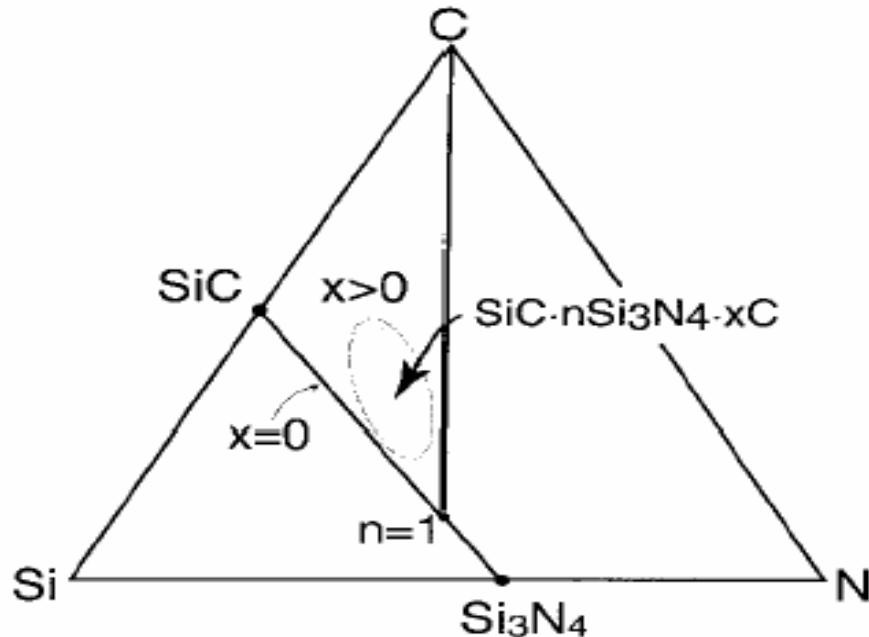


# Polymer-Derived Ceramics

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Work in collaboration with the University of Colorado at Boulder  
Professor Rishi Raj

# Composition diagram and the properties of SiCN PDC materials

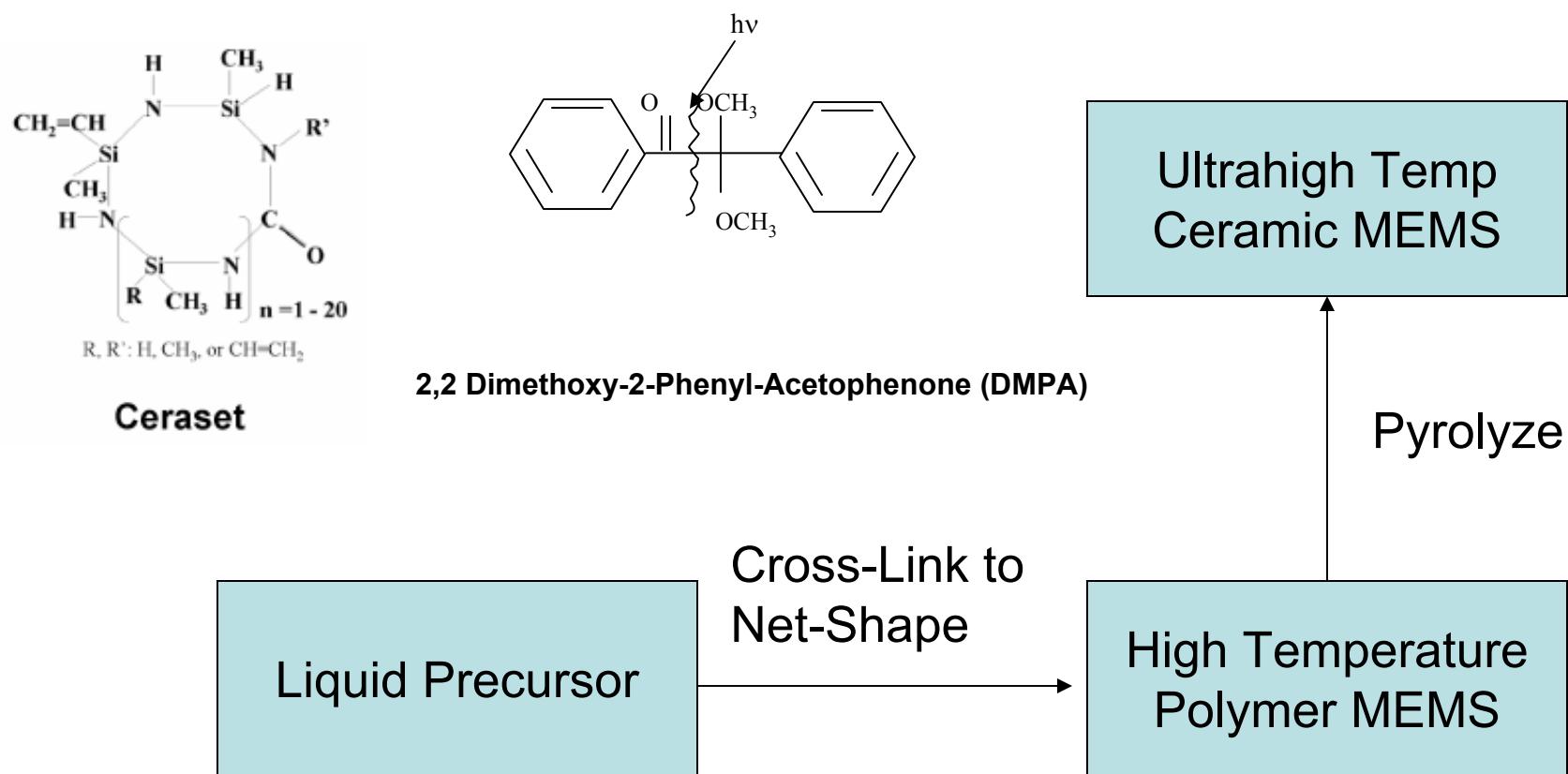


	SiCN	SiC	$Si_3N_4$
Density (g/cm <sup>3</sup> )	<b>2.35</b>	3.17	3.19
E Modulus (GPa)	<b>150</b>	405	314
Poisson's Ratio	<b>0.17</b>	0.14	0.24
CTE ( $\times 10^{-6}/K$ )	<b>~ 3</b>	3.8	2.5
Hardness (GPa)	<b>25</b>	30	28
Strength (MPa)	<b>1100</b>	418	700
Toughness (MPa.m <sup>1/2</sup> )	<b>3.5</b>	4 - 6	5 - 8
Thermal Shock FOM*	<b>2300</b>	270	890
Creep rate at 1350 °C (s <sup>-1</sup> )	<b>&lt; 10<sup>-8</sup></b>	$\sim 10^{-9}$	$\sim 10^{-9}$
Oxidation rate at 1350 °C (cm/hr <sup>1/2</sup> )	<b><math>\sim 10^{-5}</math></b>	$\sim 10^{-5}$	$\sim 10^{-5}$

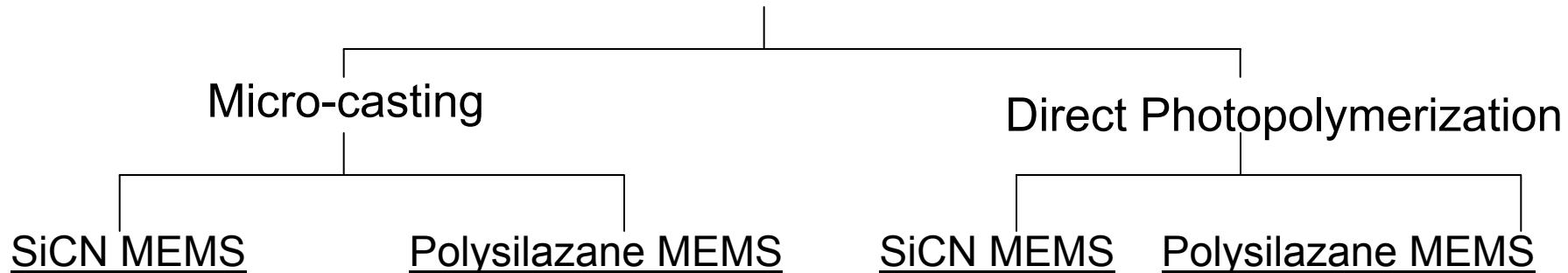
\* strength/(E-modulus.CTE)

Raj et. al.

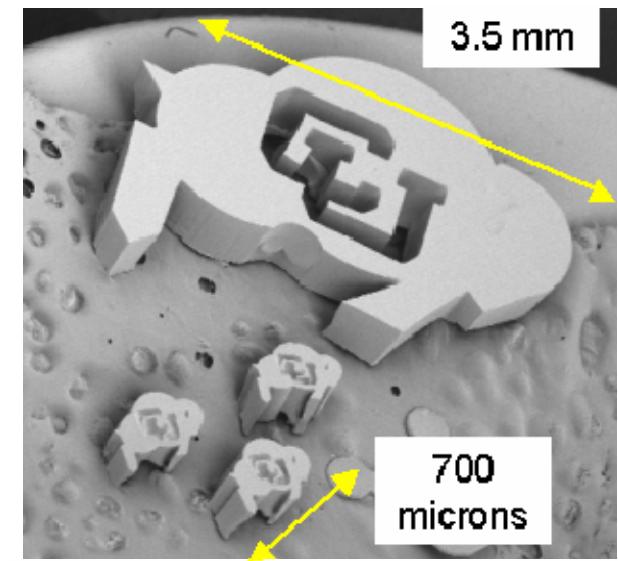
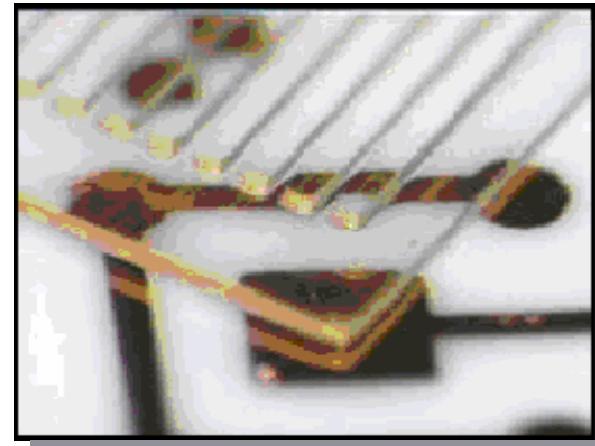
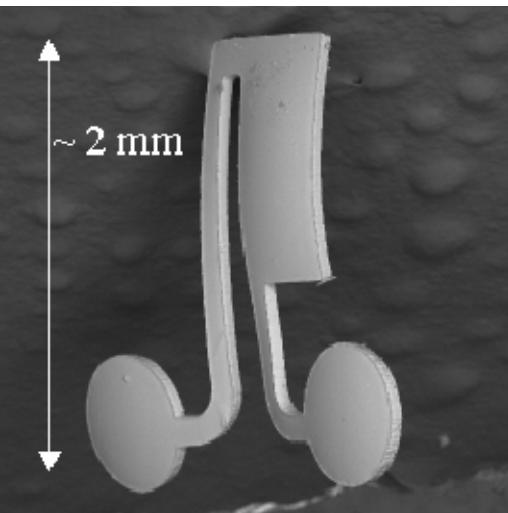
# Fabrication route for polymer-derived ceramics



# Polymer Micromachining

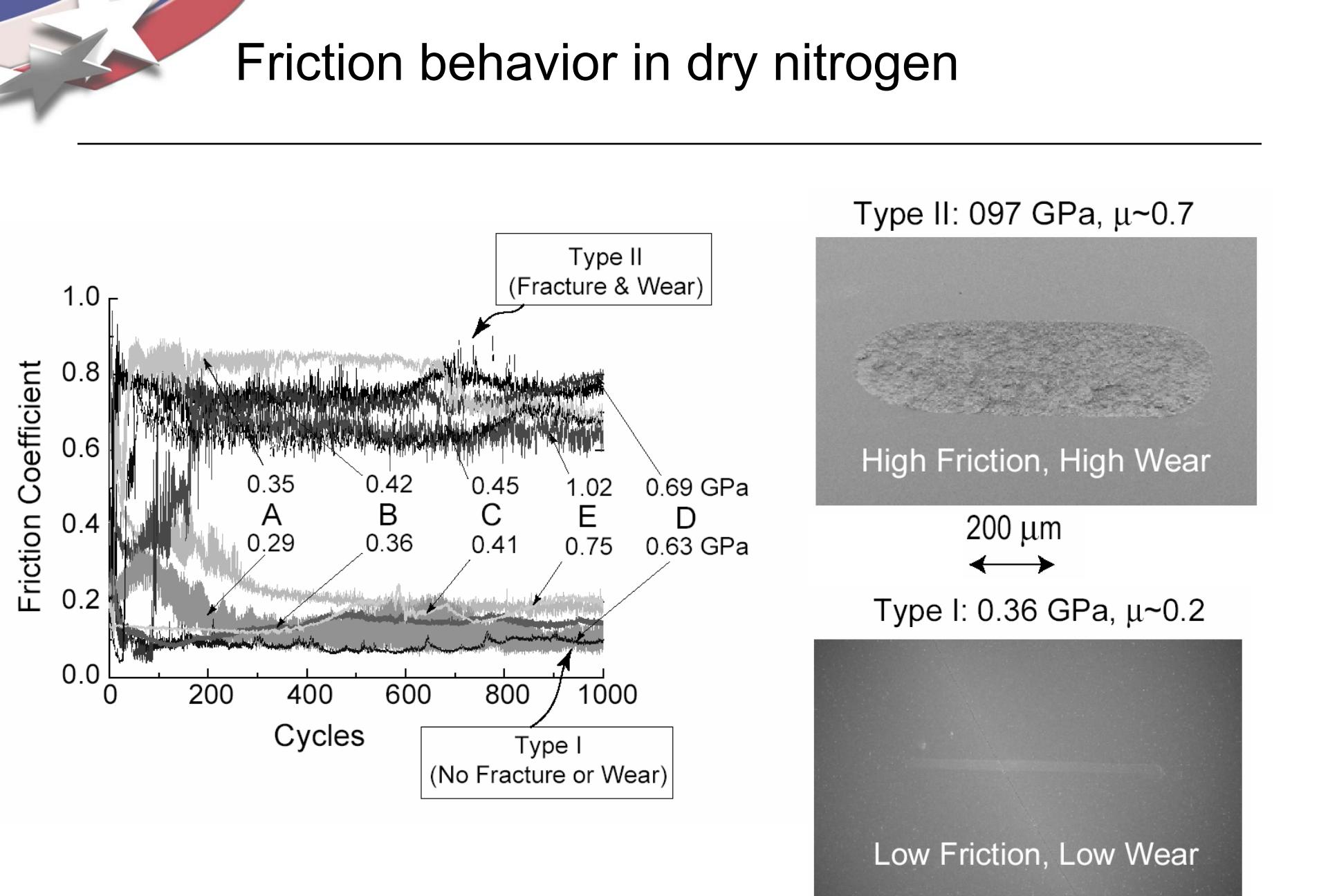


Cast in SU8 molds, followed  
by de-molding

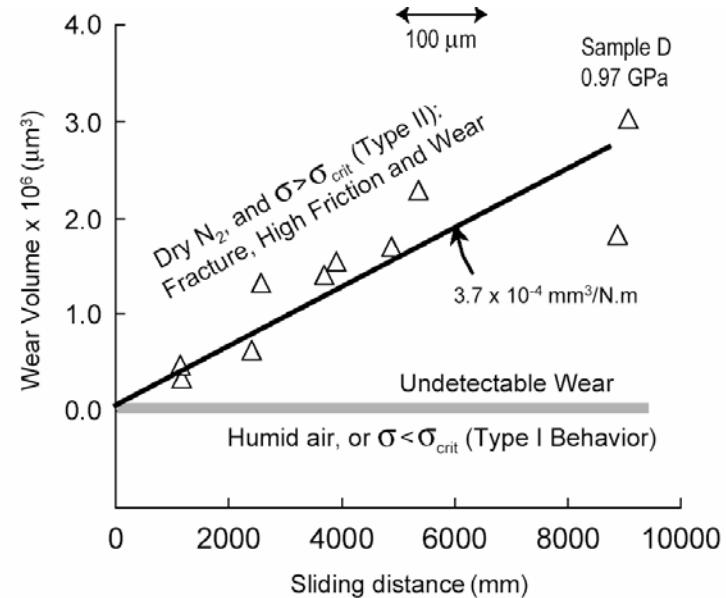
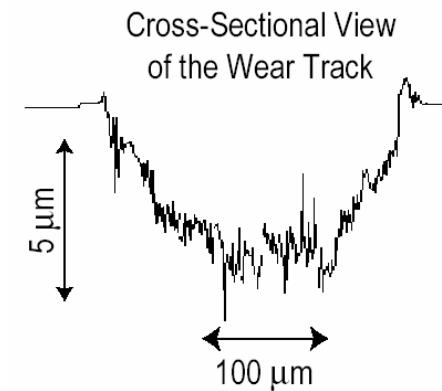
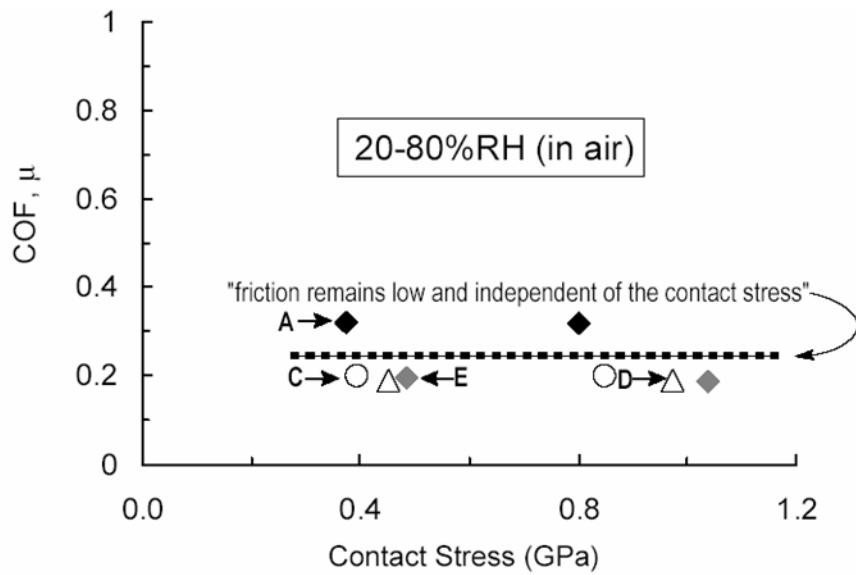
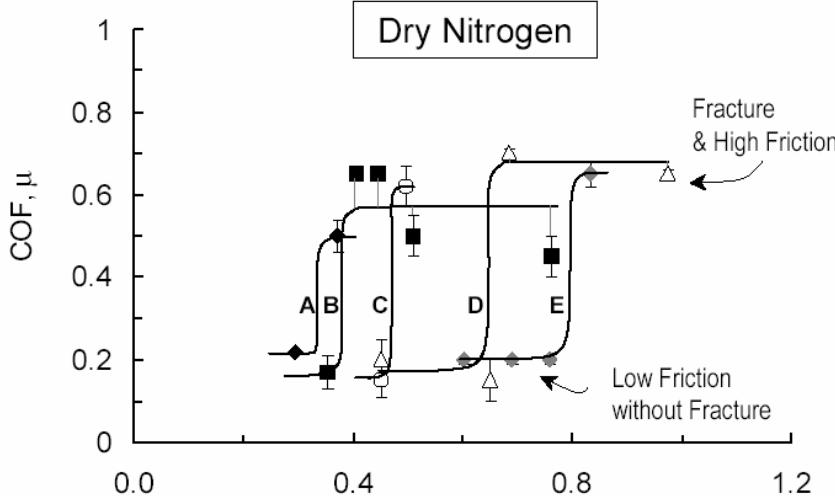


Preceramic polymer buffaloes, 500  
microns thick

# Friction behavior in dry nitrogen



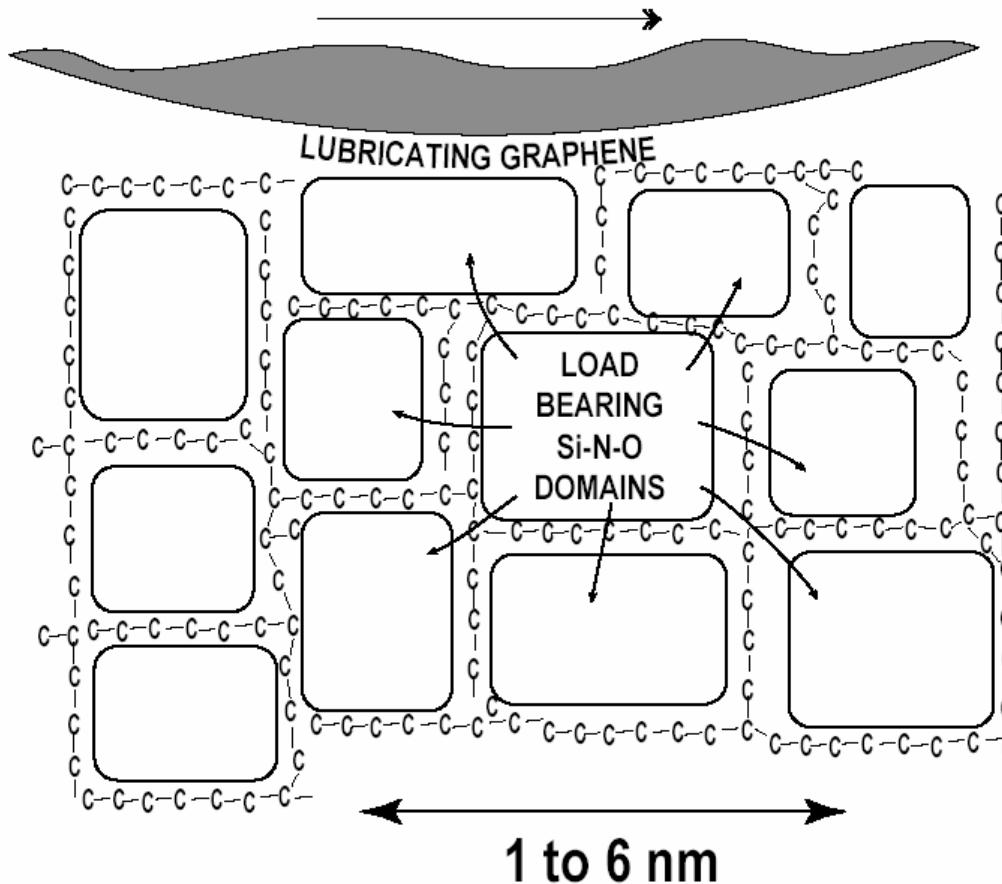
# Environmental effects on friction and wear transitions





# Schematic depiction of dual-phase structure in SICNO

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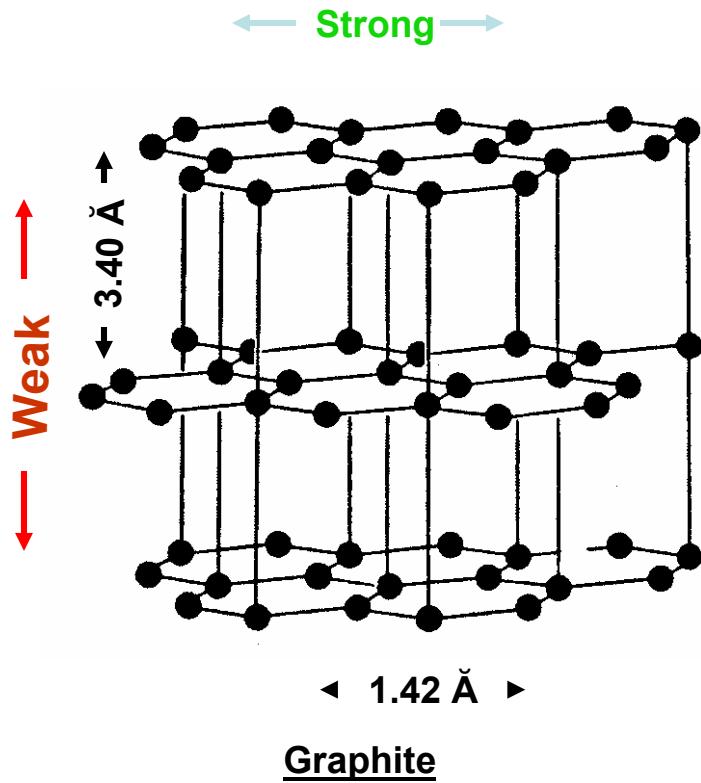




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# Solid Lubricants

# Lubrication by graphite



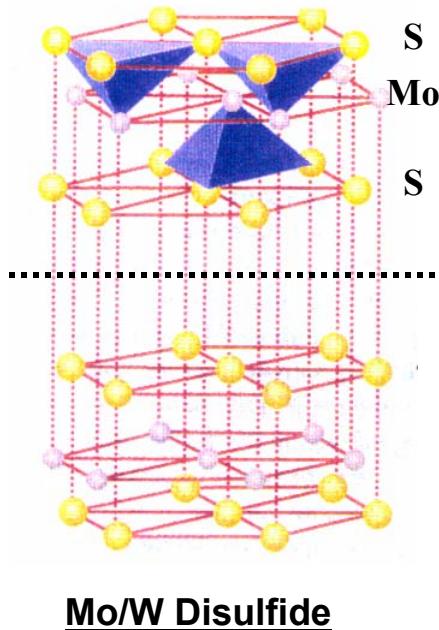
Element C (four valence electrons) can exist in different allotropic forms

- $sp^2$  bonding configuration (crystalline graphite as shown in the right): basal planes held with strong covalent bonds, while the planes are held with weak Van der Waals forces. This gives rise to [interlamellar mechanical weakness](#). Other  $sp^2$  kinds include: carbon-carbon composites, unhydrogenated carbon, etc.
- $sp^3$  bonding in diamond
- Hydrogenated carbon with various degrees of  $sp^2/sp^3$  bond ratios that are commonly known as diamond-like carbon.

Graphite needs moisture or adsorbed gases in the environment (>100 ppm) (they either act as intercalants, or passivate the dangling covalent bonds) to lubricate.

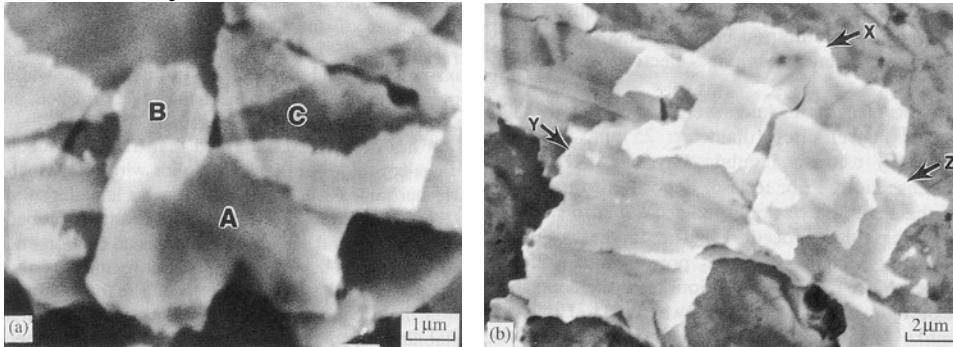
In vacuum, graphite exhibits high friction and wear—a phenomenon known as “dusting”, first observed in the late 1930’s when graphite brushes in aircrafts experienced accelerated wear at high altitudes.

# Transition metal dichalcogenides ( $\text{MoS}_2$ , $\text{WS}_2$ )

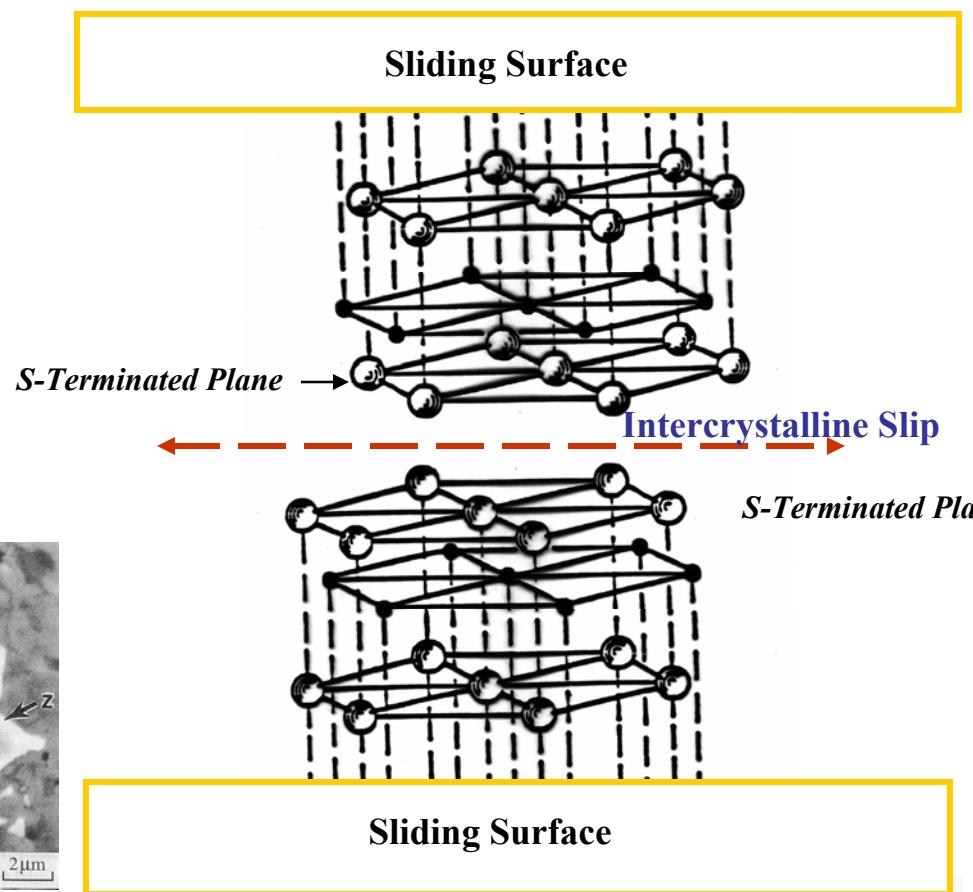


**Mo/W Disulfide**

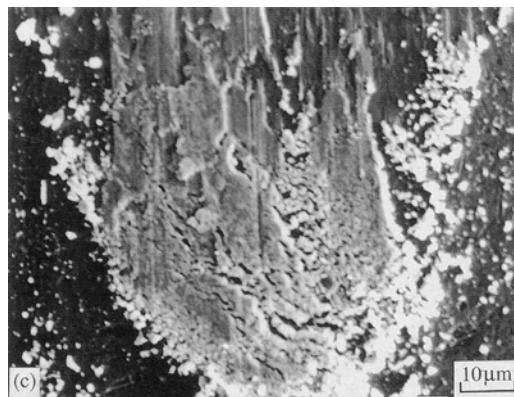
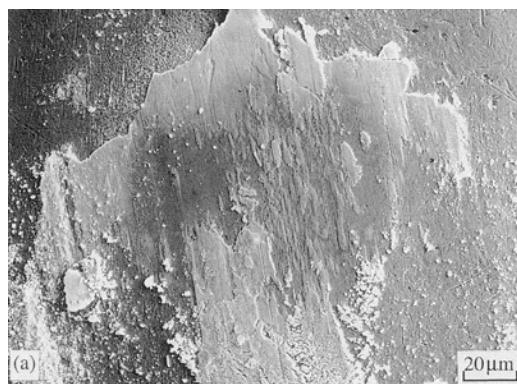
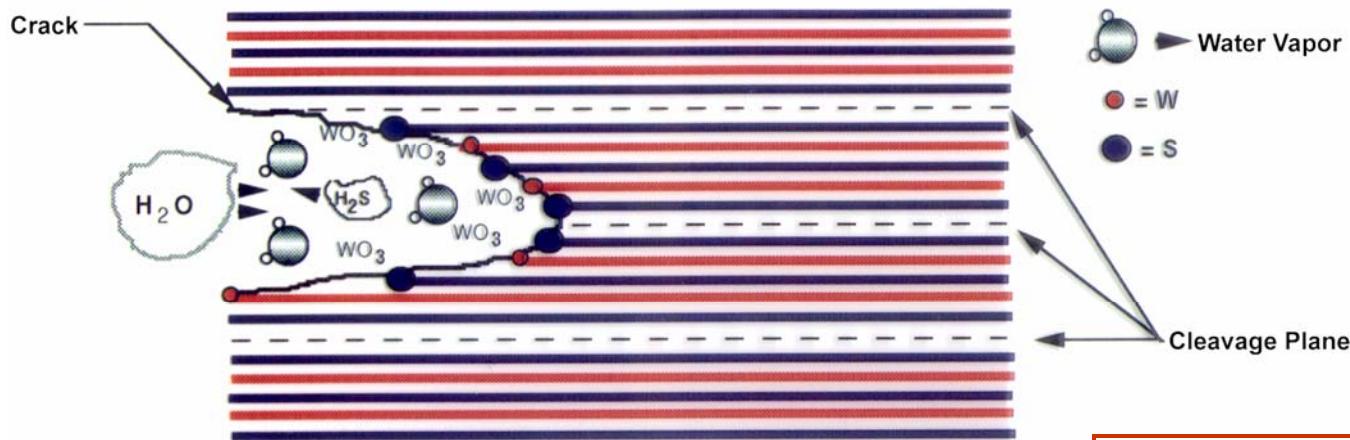
They form thin transfer films on the counterface



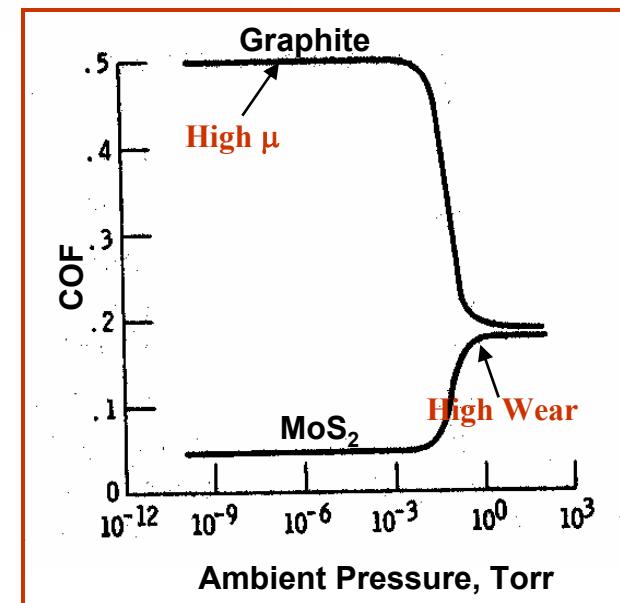
Extremely low COF (0.01-0.05) and long wear life (millions of wear cycles for a micron thick  $\text{MoS}_2$  film), **but only in dry environments**.



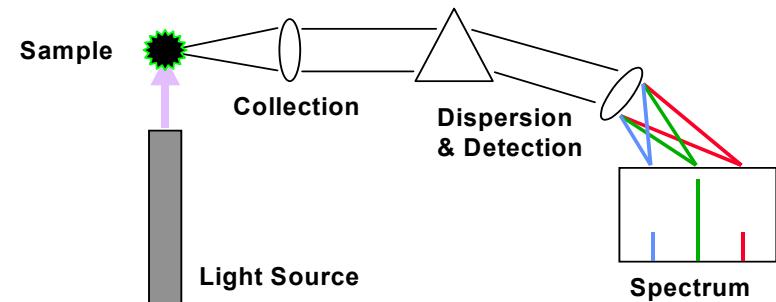
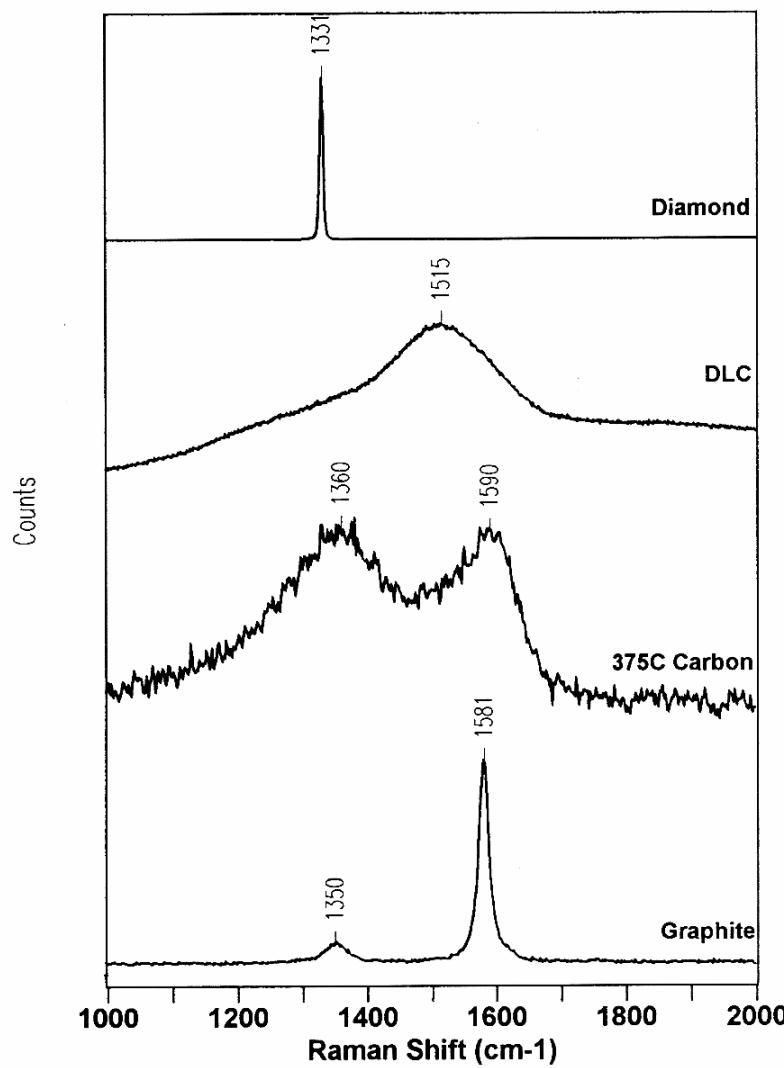
# Oxidize in humid environments, losing their ability to lubricate



Typical transfer films ( $WS_2$ ) in humid air



# Carbon can exist in different forms



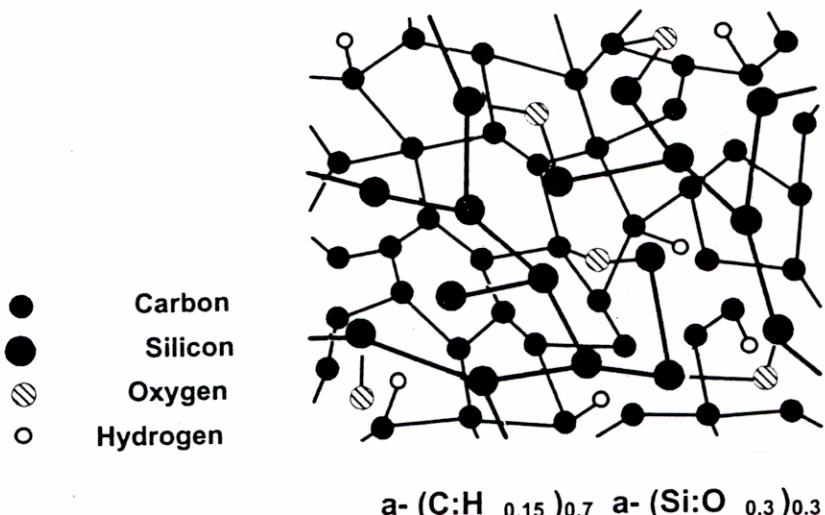
Argon laser: 458 nm wavelength  
Spot size: 1  $\mu$ m (Microscope Accessory)

D. R. Tallant et. al, *Diamond and Related Materials* 4 (1995) 191-199

# Diamond like nanocomposite (DLN) coatings were produced by PECVD (Source: Bekart Advanced Coating Technologies)

## Plasma Enhanced CVD

### Ployphenylmethylsiloxane precursor



Schematic of DLN atomic structure.

Interpenetrating random networks  
DLC (a-C:H) and glass like a-Si:O

- Conformal coatings could provide coverage of sidewalls
- Substrate temperatures do not typically exceed 150 to 200 °C

Hardness: 9-17 GPa  
Modulus: 90-140 GPa

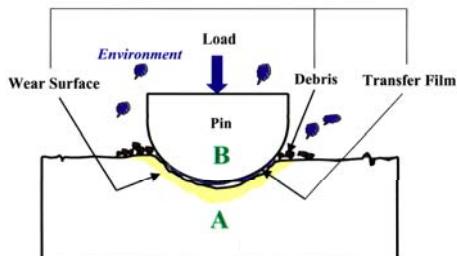
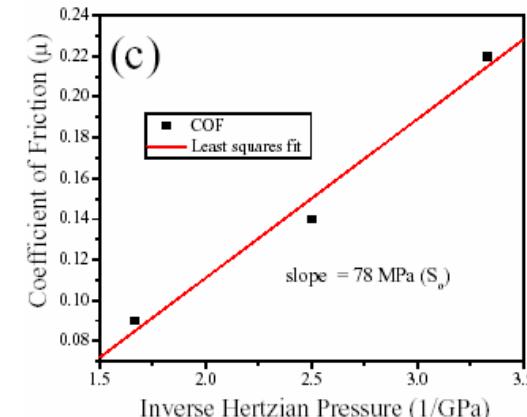
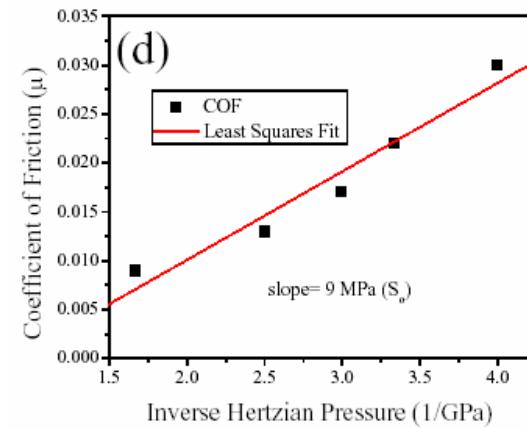
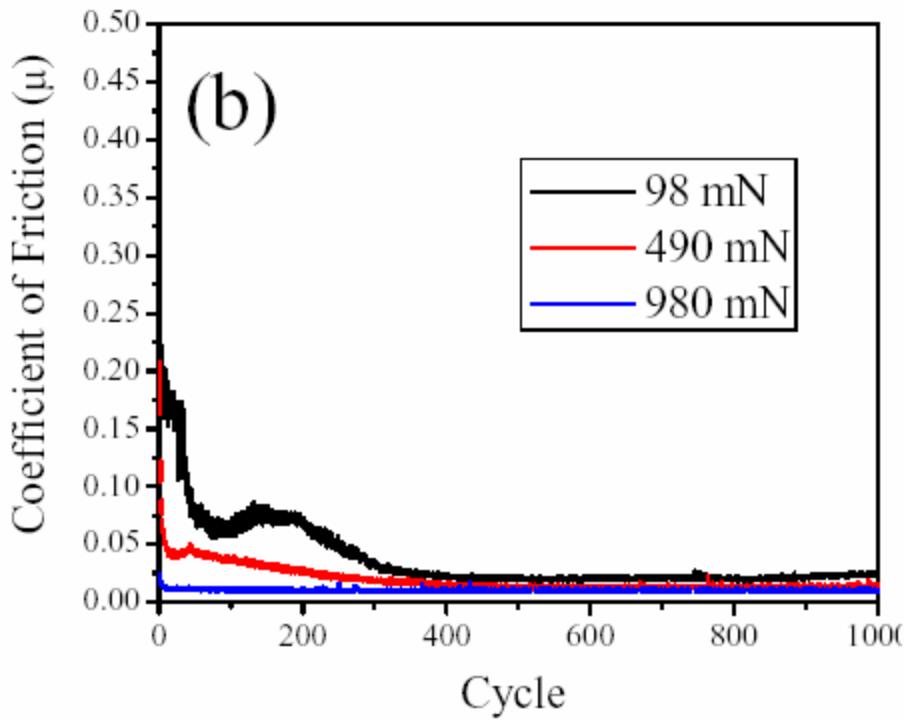
V. F. Dorfman, *Thin Solid Films*, 212 (1992) 267-273

D. J. Kester, C. L. Brodbeck, I. L. Singer and A. Kyriakopoulos, *Surface and Coatings Tech.* 113 (1999) 268-273.

C. Venkatraman, C. Brodbeck and R. Lei, *Surface and Coatings Tech.* 115 (1999) 215-221.



# Many solid lubricants exhibit is non-Amontonian friction behavior

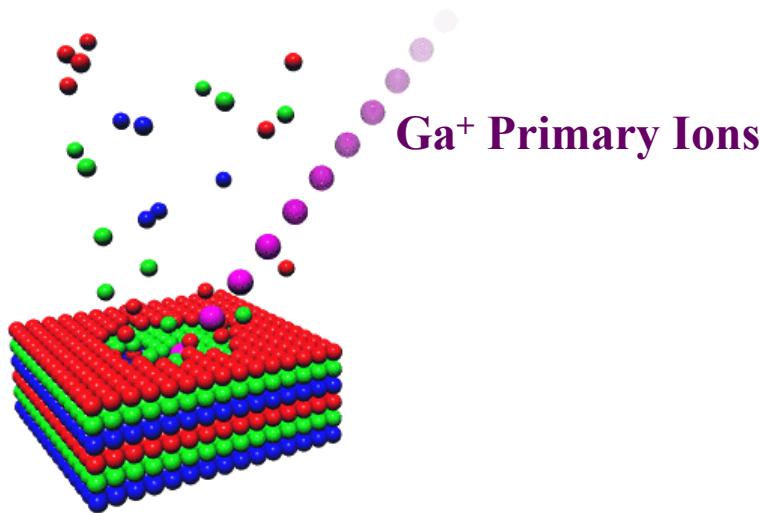


$$\mu = S_0/P + \alpha$$

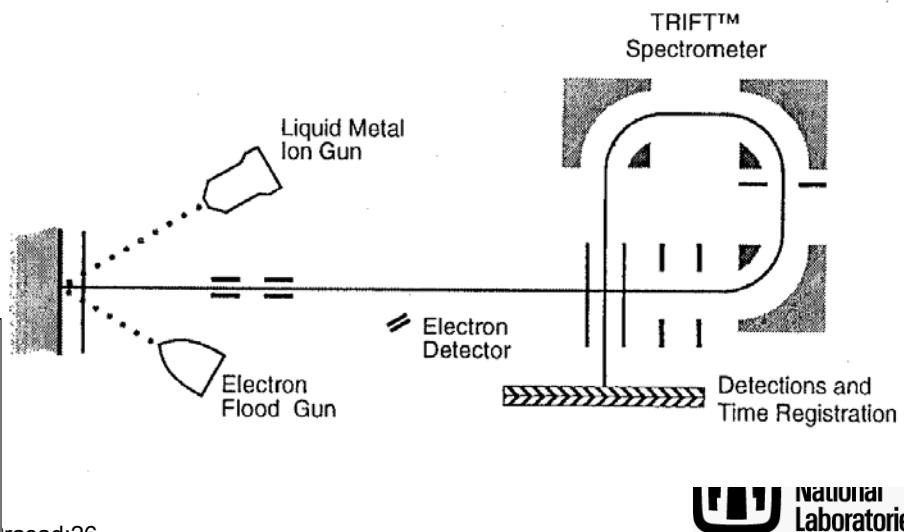
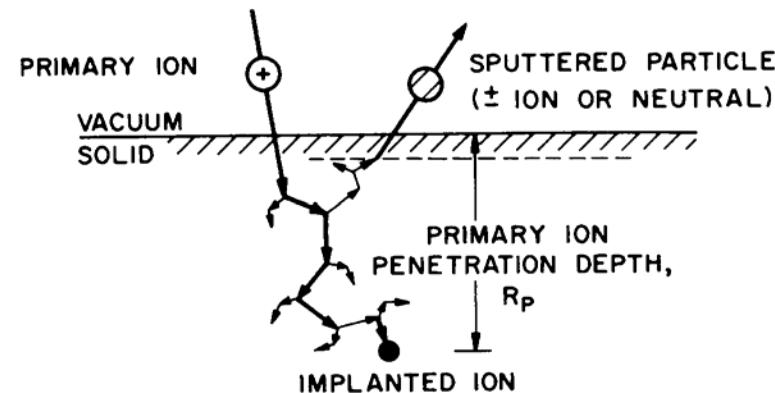
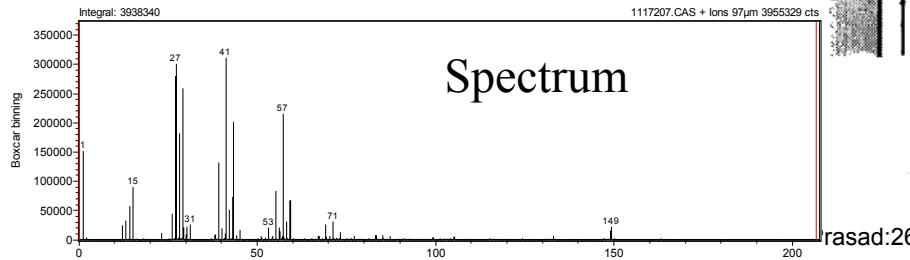


# Time-of-Flight Secondary Ion Mass Spectrometry

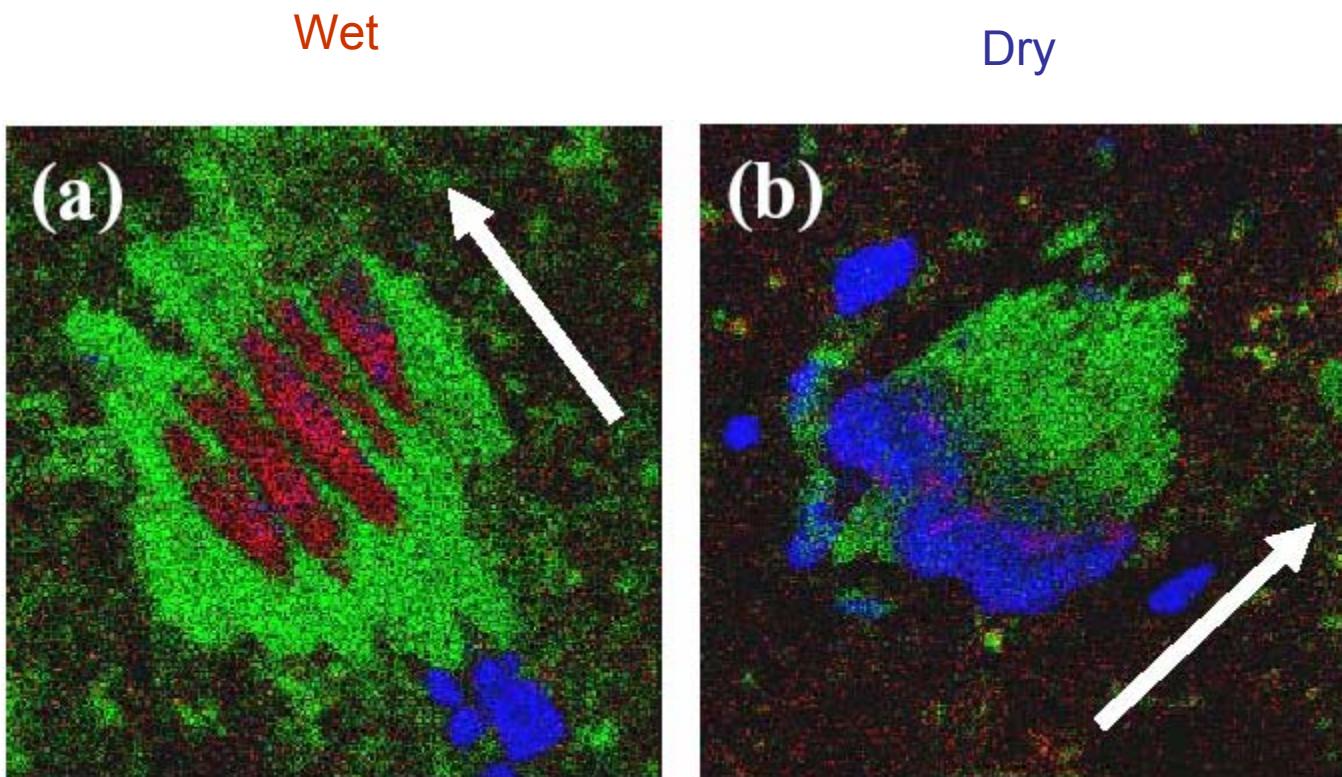
$+$ / $-$  Ions and Neutrals  
ejected from surface  
(Elemental and Molecular)



Spectrum



# Spectral Imaging and Multivariate Analysis



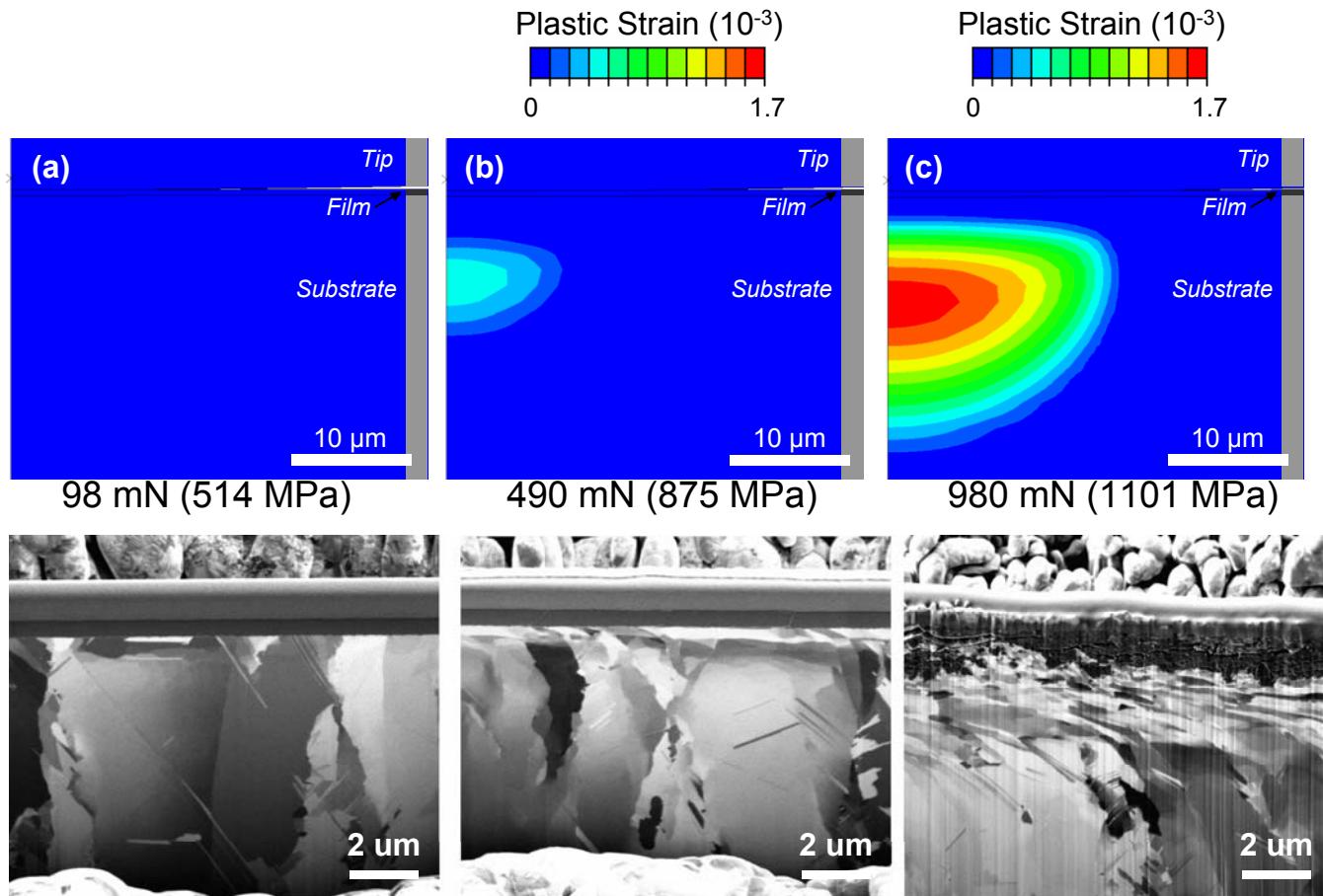
Red:  $\text{SiO}_2$  ( $\text{O} + \text{Si} + \text{SiO}_2 + \text{SiO}_3$ )

Green: Long Range Carbon (C<sub>1</sub> to C<sub>4</sub> fragments)

Blue: Hydrogenated Carbon ( $\text{CH} + \text{CH}_2 + \text{C}_2\text{H}$ )



# FEA and FIB can reveal the onset of substrate plastic deformation



Generation of plastic strain under 1/8"  $\text{Si}_3\text{N}_4$  ball on DLN-coated Ni at peak contact stresses of (a) 507 MPa [98 mN], (b) 864 MPa [490 mN] and (c) 1088 MPa [980 mN].



# Tribological issues in MEMS

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## Microelectromechanical Systems (MEMS)

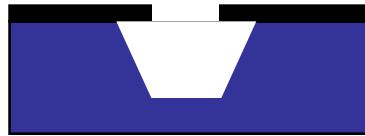


# A variety of fabrication methods can be used to construct microsystems

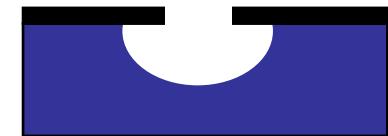
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## Bulk Micromachining

- subtractive process; pattern and etch
- well established for Si; also done in GaAs



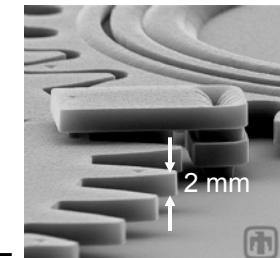
anisotropic



isotropic

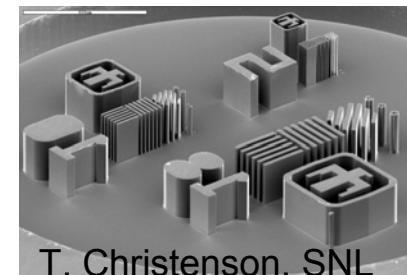
## Surface Micromachining

- additive process; structural (Si) and sacrificial ( $\text{SiO}_2$ ) layers
- dissolve sacrificial layers to free structures



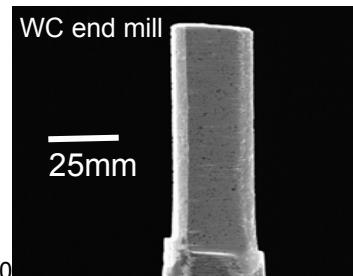
## Lithographie, Galvanoformung und Abformung (LIGA)

- plate or press into thick polymer mold
- micron to centimeter scale parts

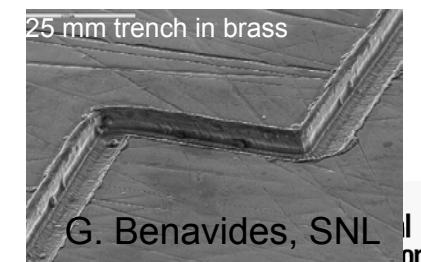


## Meso-Machining

- subtractive process; push machining methods to micron scale
- micro-milling, micro-EDM, plunge EDM



IDGA\_Prasad:30

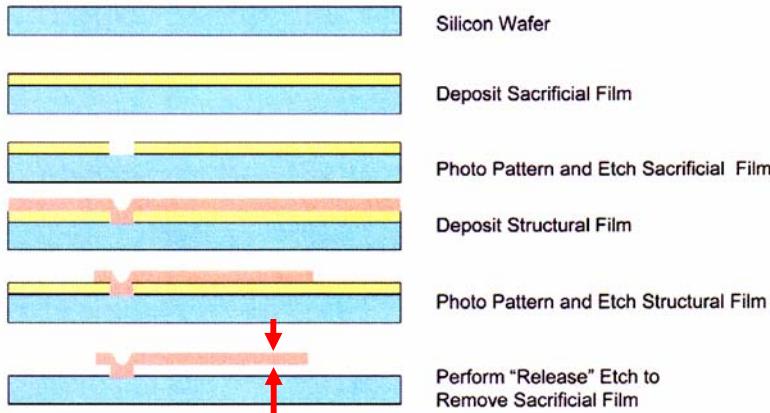


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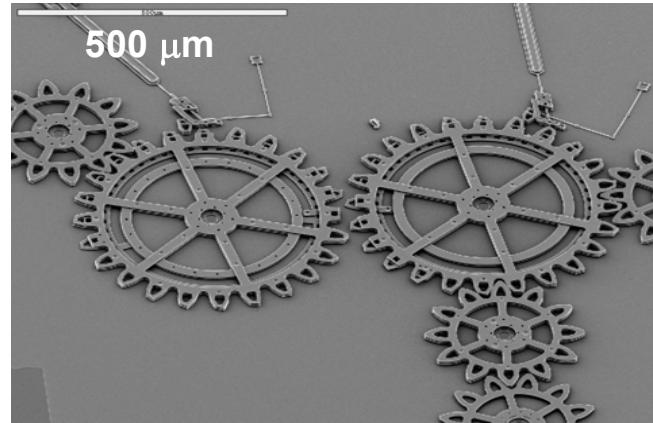
# Surface Micromachined (SMM) Silicon Devices

Microfabrication with silicon leverages decades of process knowledge  
Mature fabrication equipment and processes

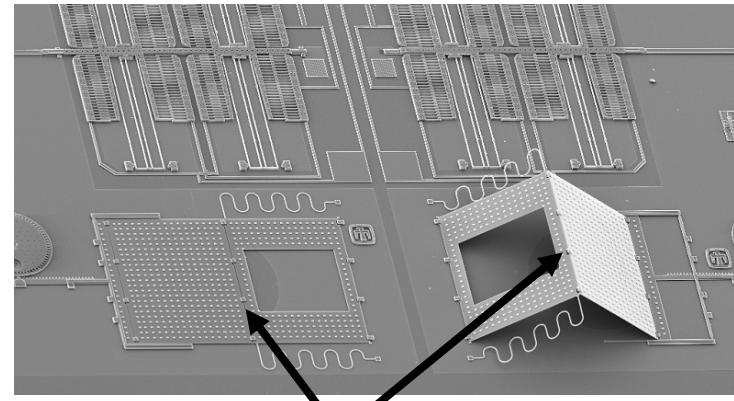


*In-process adhesion (stiction) is no longer a significant barrier to successful device fabrication and initial operation*

- Dynamic Interfaces (Tribology)
- Dormancy and Materials Aging
- Surfaces (Buried/Hidden)

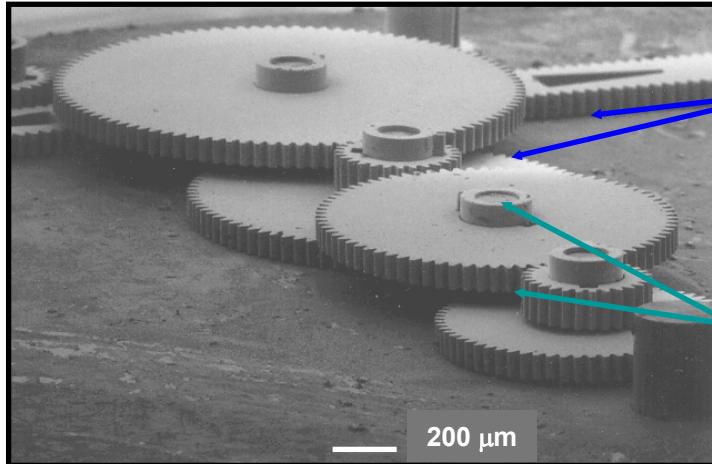


actuators, guides and gears used to achieve motion





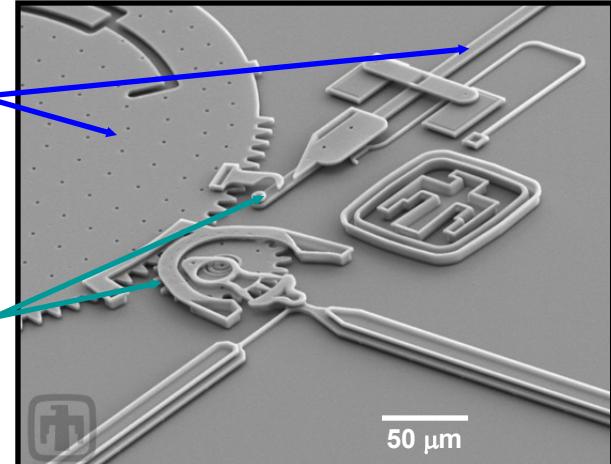
# Microsystems frequently contain rubbing surfaces



Electroformed Ni transmission

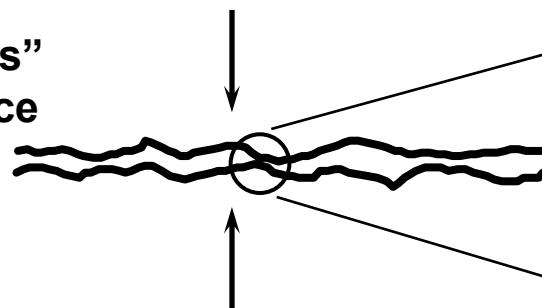
Planar contact

Sidewall contact

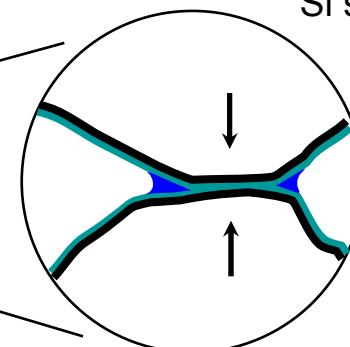


Si surface micromachined lock

**“Macromachines”**  
applied force  
inertia



**“Micromachines”**  
capillary  
electrostatic  
Van der Waals



**Surface interactions dominate as machine scale is reduced**

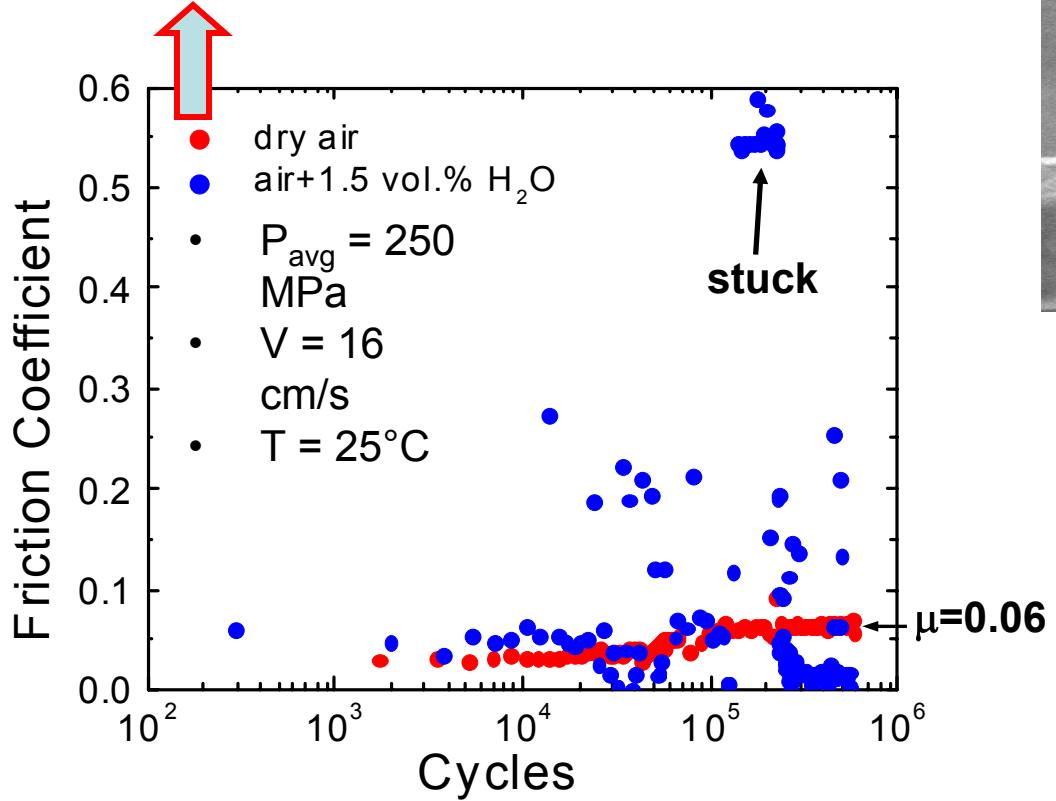
*dormancy*  $\longleftrightarrow$  *friction, wear*  $\longrightarrow$  *reliability*

**Apply novel, small scale experimental techniques to study tribology.**

# Friction evolution in FTS-coated devices exhibits a strong dependence on the presence of water vapor

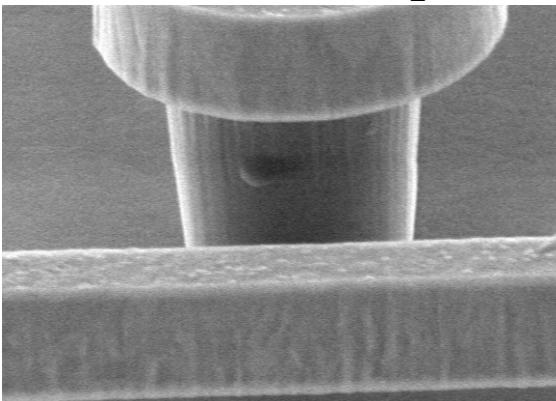
Lubricated with  
Perfluorodecyltrichlorosilane (FTS)  
 $\text{CF}_3(\text{CF}_2)_7(\text{CH}_2)_2\text{SiCl}_3$

## Uncoated Devices

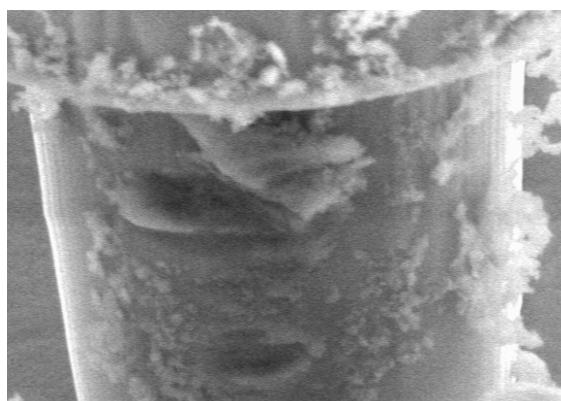


Courtesy: M. T. Dugger (mtdugge@sandia.gov)  
Romig AD, Dugger MT, McWhorter, Acta Materialia 51 (2003) 5837

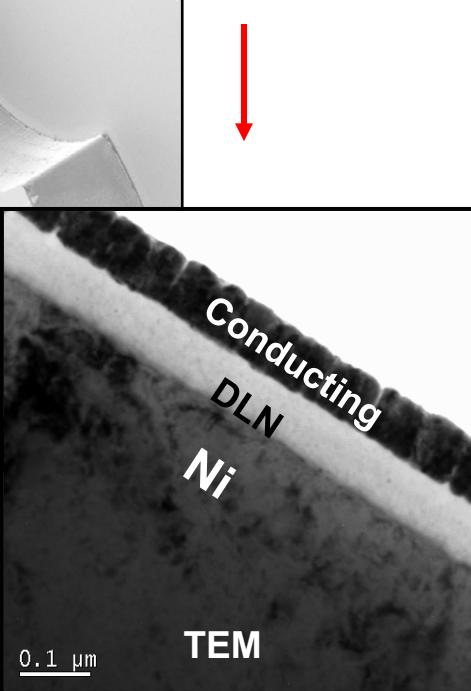
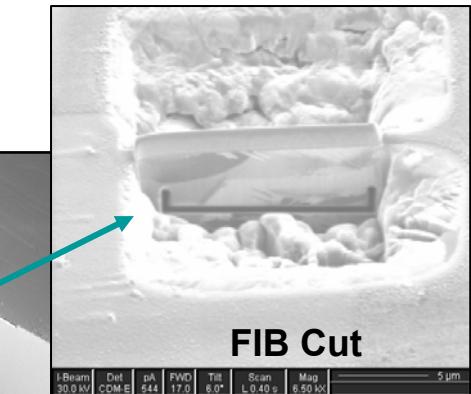
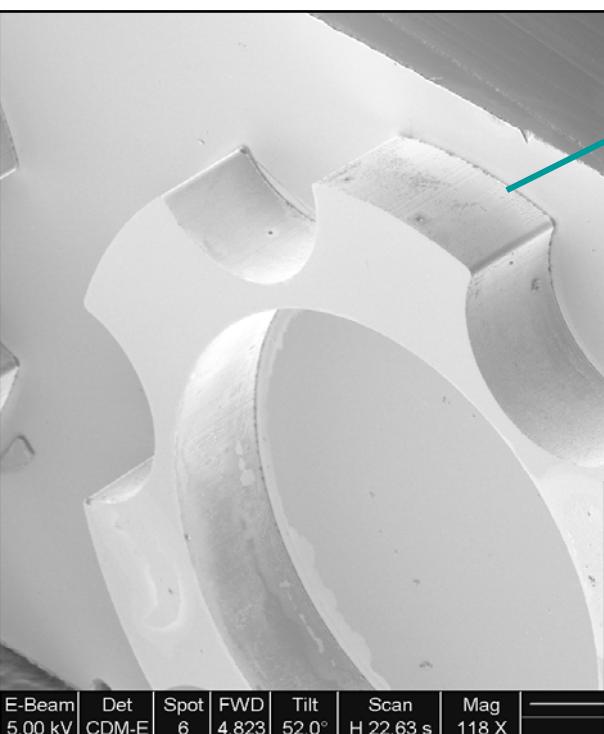
dry air (100 ppm  $\text{H}_2\text{O}$ )



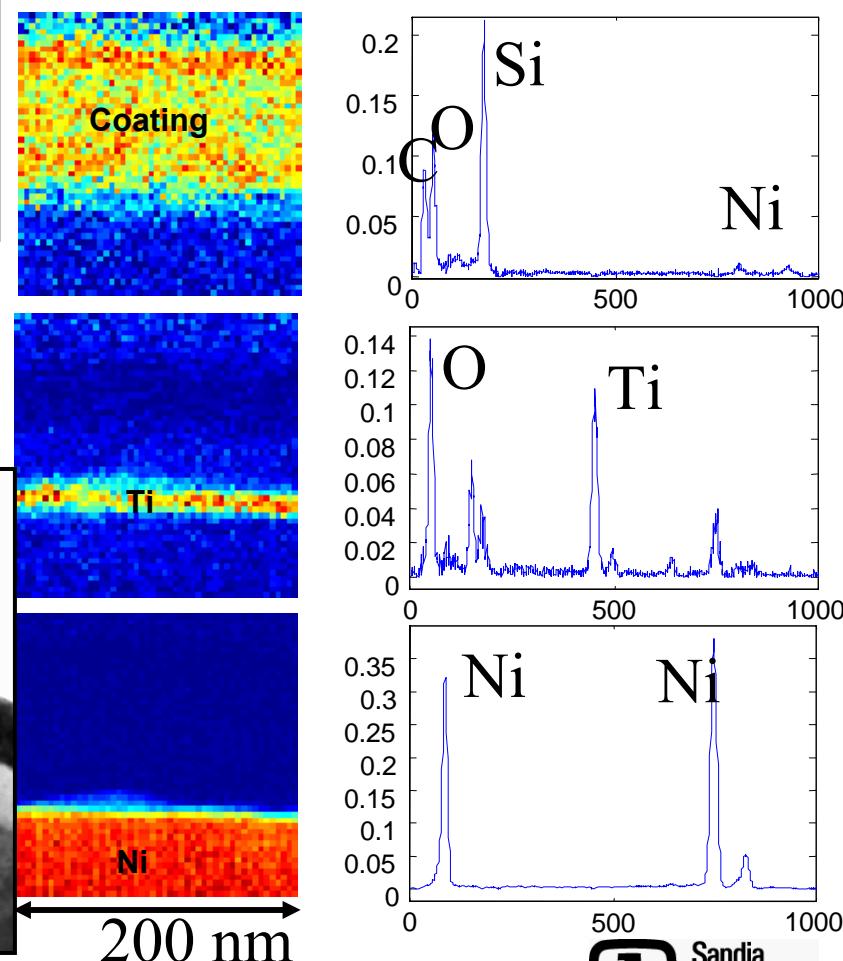
air+1.5 vol.%  $\text{H}_2\text{O}$  (40%RH)



# Novel techniques are necessary to characterize the chemistry and coverage on the sidewalls of miniature parts



X-ray Spectral Image Analysis



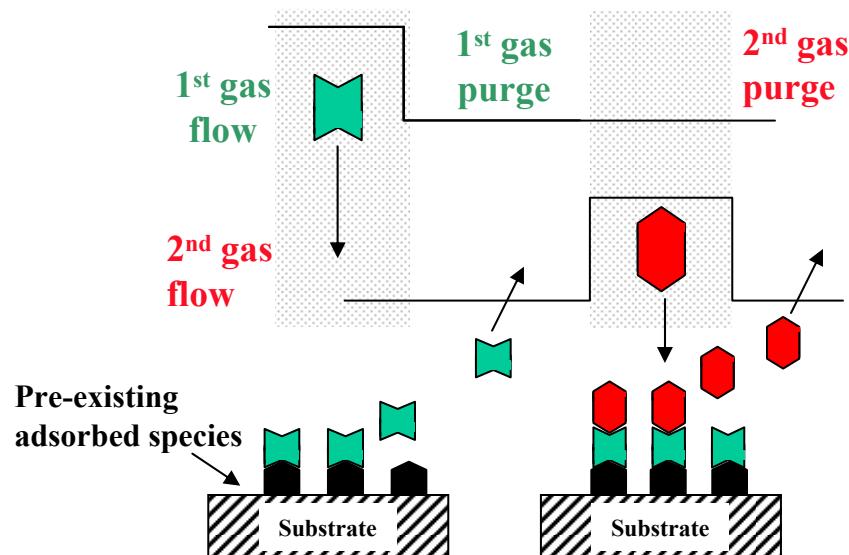


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# Atomic Layer Deposition (ALD)

# Atomic Layer Deposition for Tribological Coatings

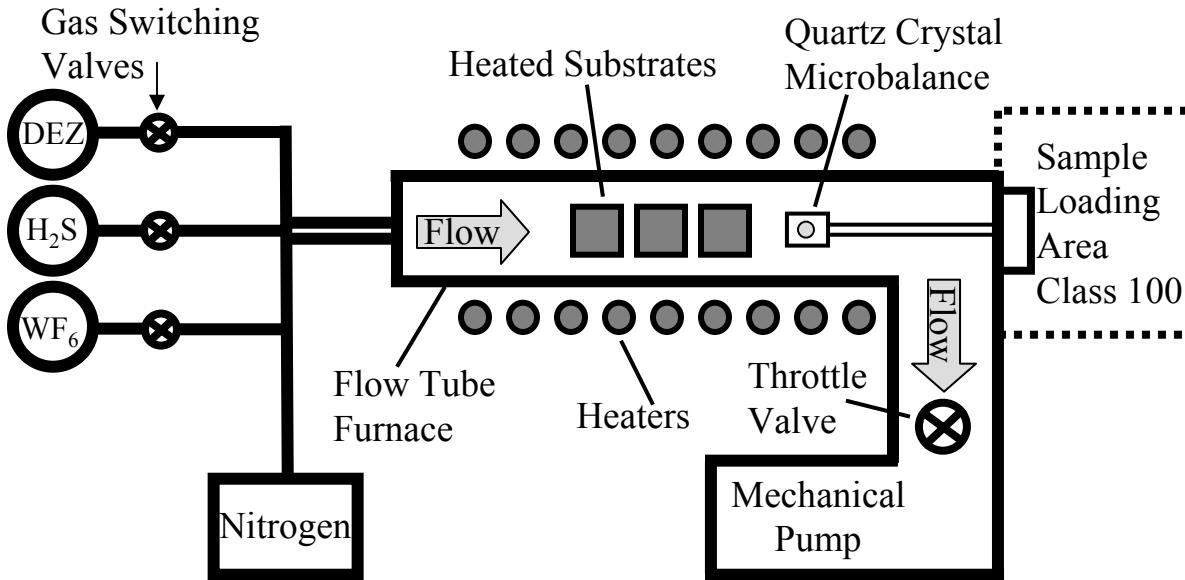
Atomic Layer Deposition (ALD) is based on sequential introduction of gaseous precursors and selective chemistry





# Schematic illustration of the ALD reactor for the synthesis of WS<sub>2</sub> films

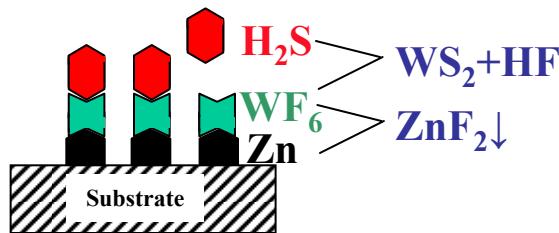
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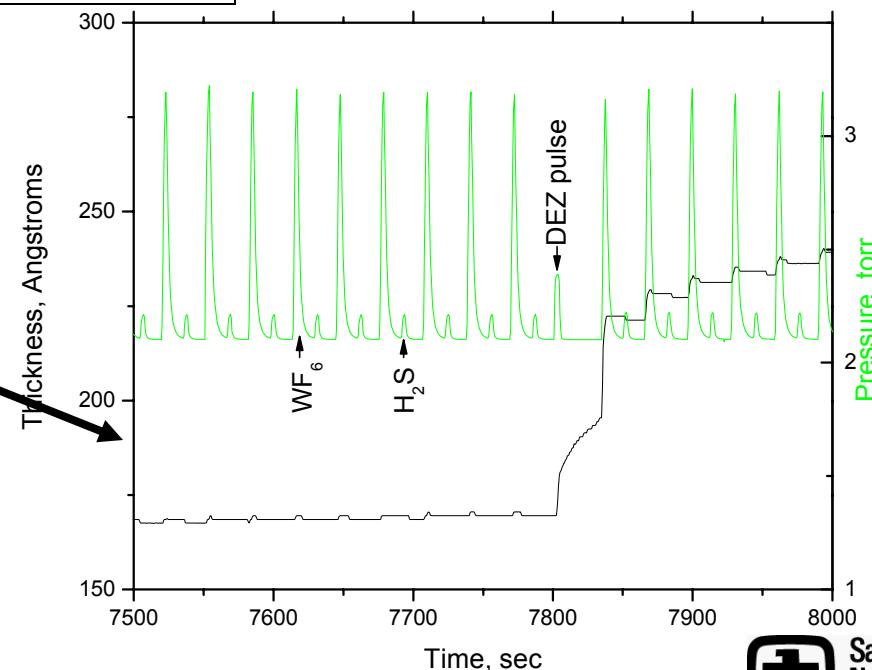
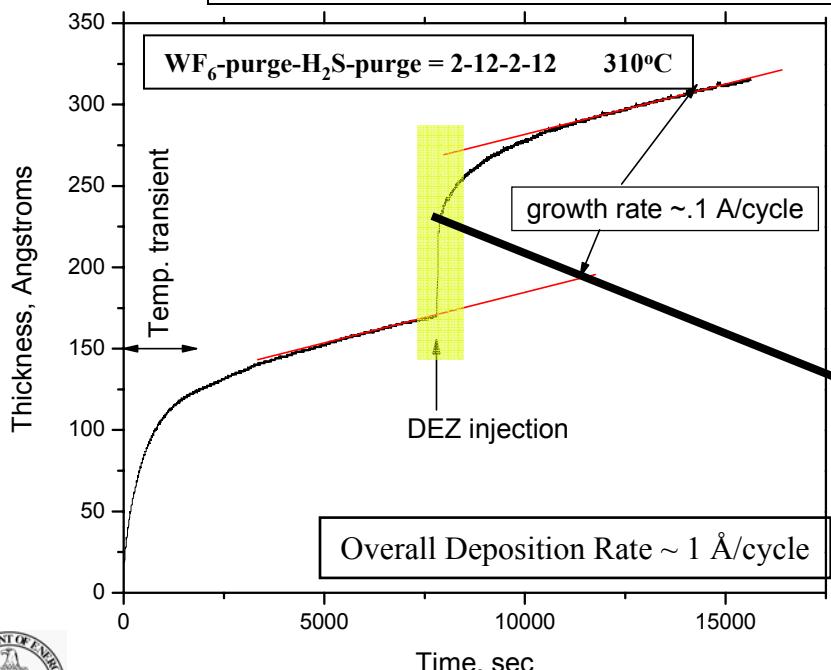
# Quartz Crystal Microbalance Provides *in-situ* Process Diagnostics

ALD  $\text{WS}_2$  is based on the CVD reaction:  $\text{WF}_6 + \text{H}_2\text{S} \rightarrow \text{WS}_2 + \text{HF}$

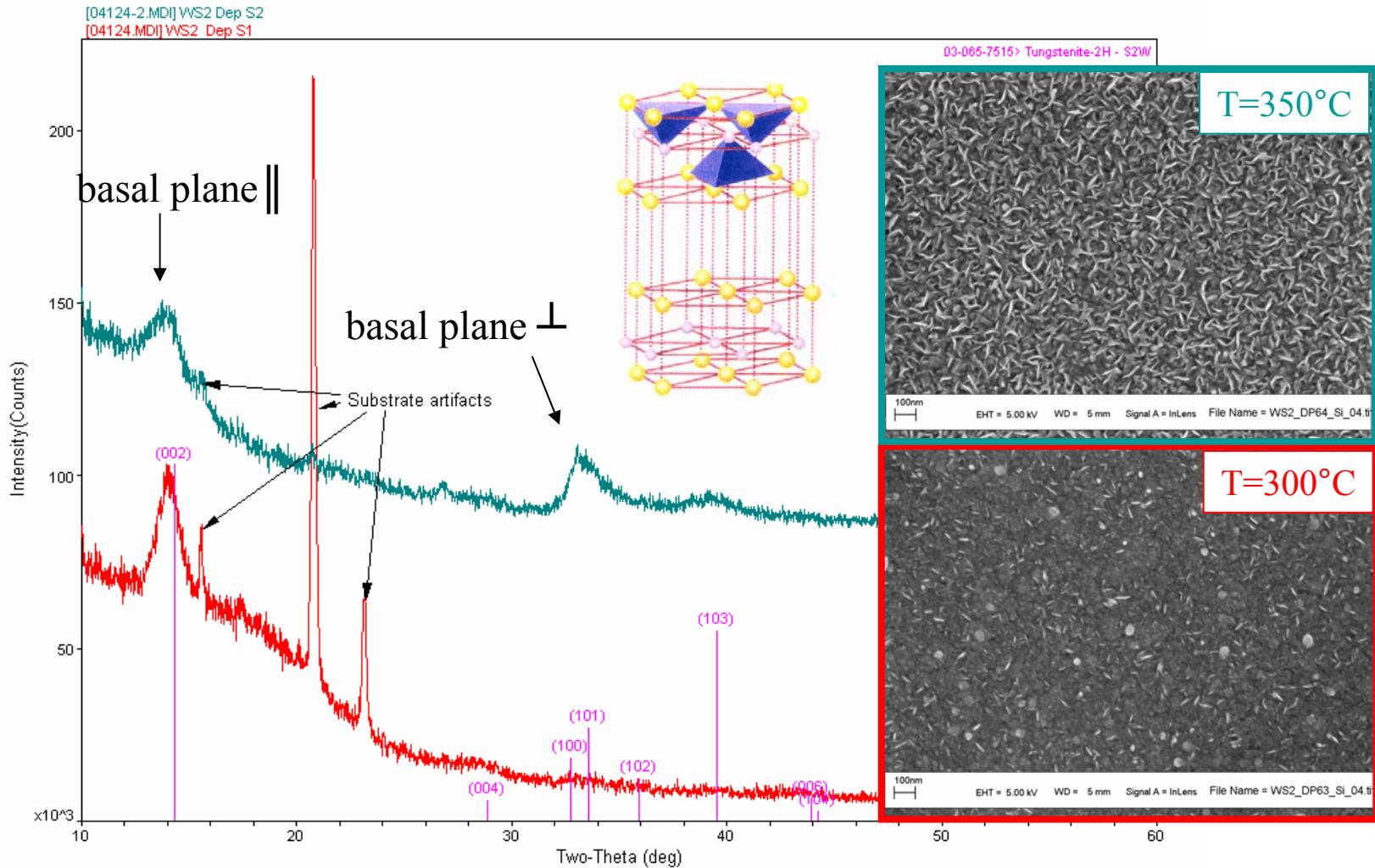
Zn catalyzed adsorption and reaction of  $\text{WF}_6$  greatly increases  $\text{WS}_2$  growth rate:



Recipe: 1 cycle of DEZ followed by 50 cycles of  $\text{WF}_6 + \text{H}_2\text{S}$



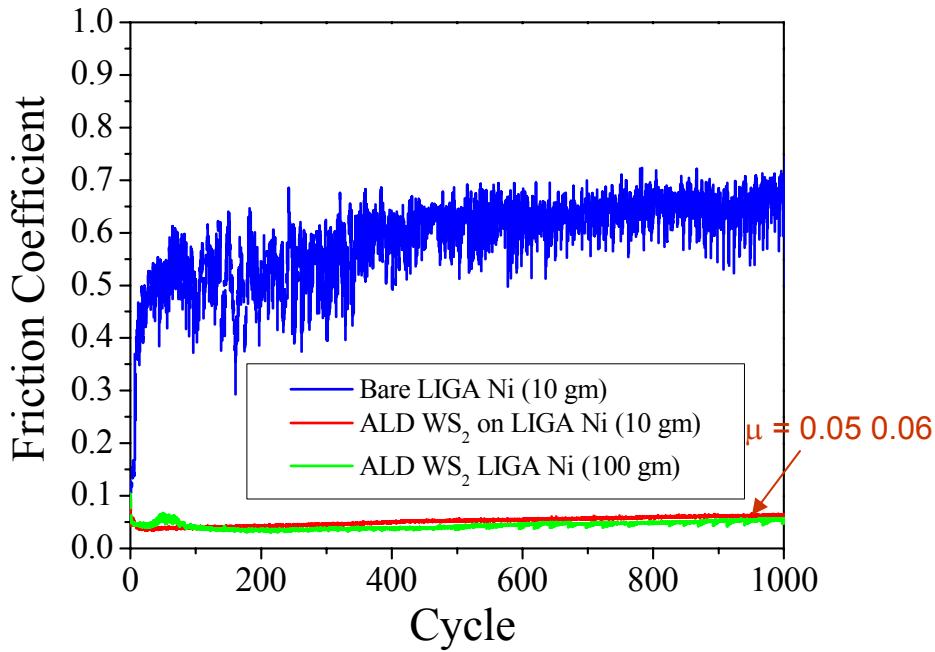
# Crystallographic texture of ALD WS<sub>2</sub> is growth temperature dependent



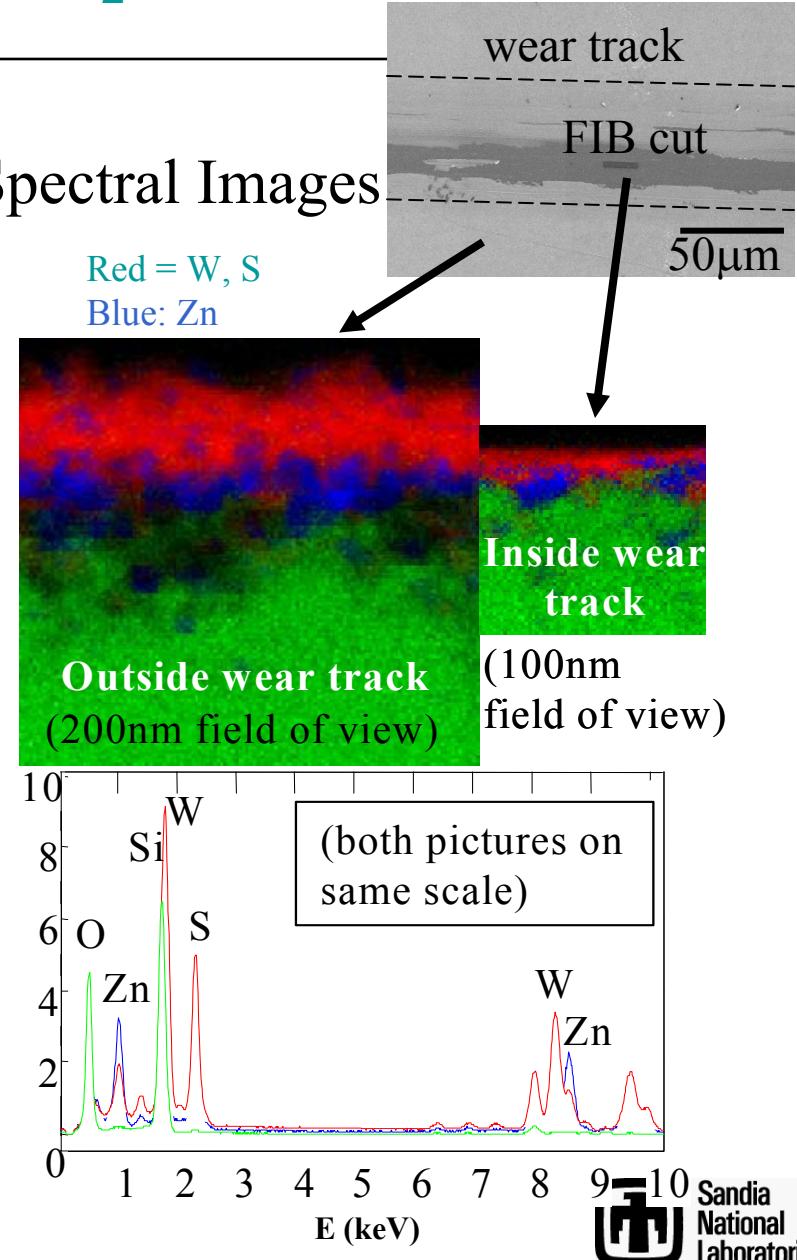
Basal plane preferred orientation effects as function of T

# Tribology of ALD WS<sub>2</sub> Films

## Friction



## Spectral Images

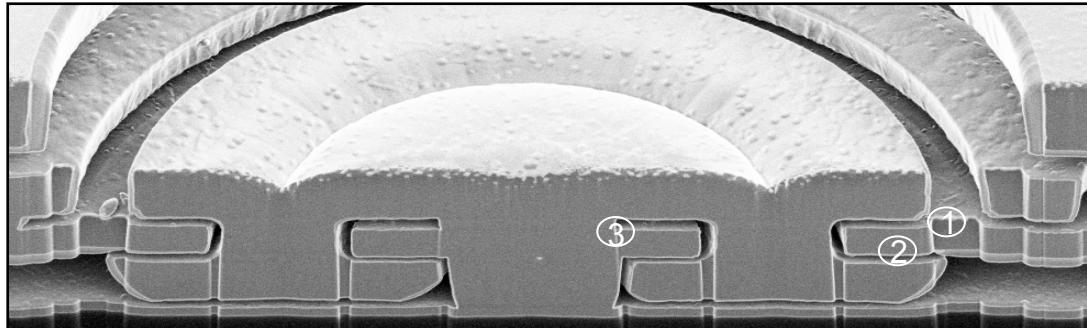


- We are able to grow ALD WS<sub>2</sub> films on a variety of substrates: Si, SiO<sub>2</sub>, Au, Stainless Steel, LIGA Ni
- Some of the wear taking place is a result of film material being transferred to the rubbing counterface (Si<sub>3</sub>N<sub>4</sub>).

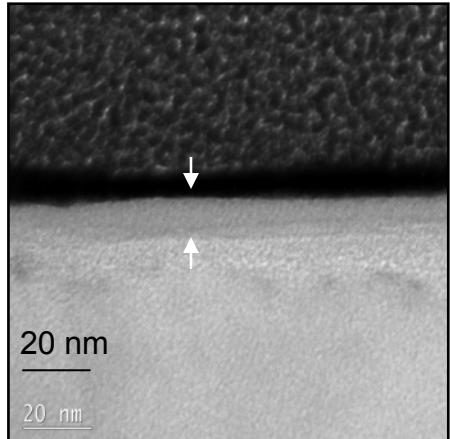


# ALD conformally coats very high aspect ratio structures and buried interfaces

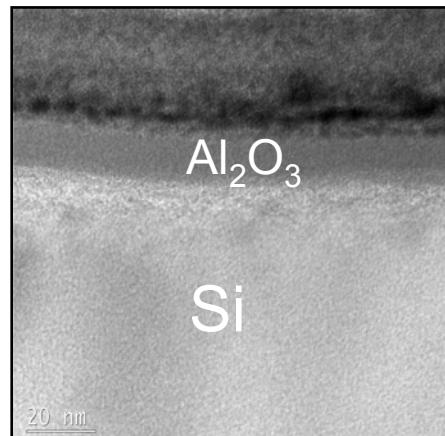
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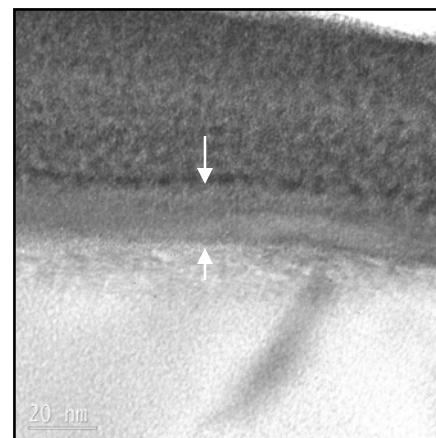
1. Gear top exposed



2. Gear bottom shadowed



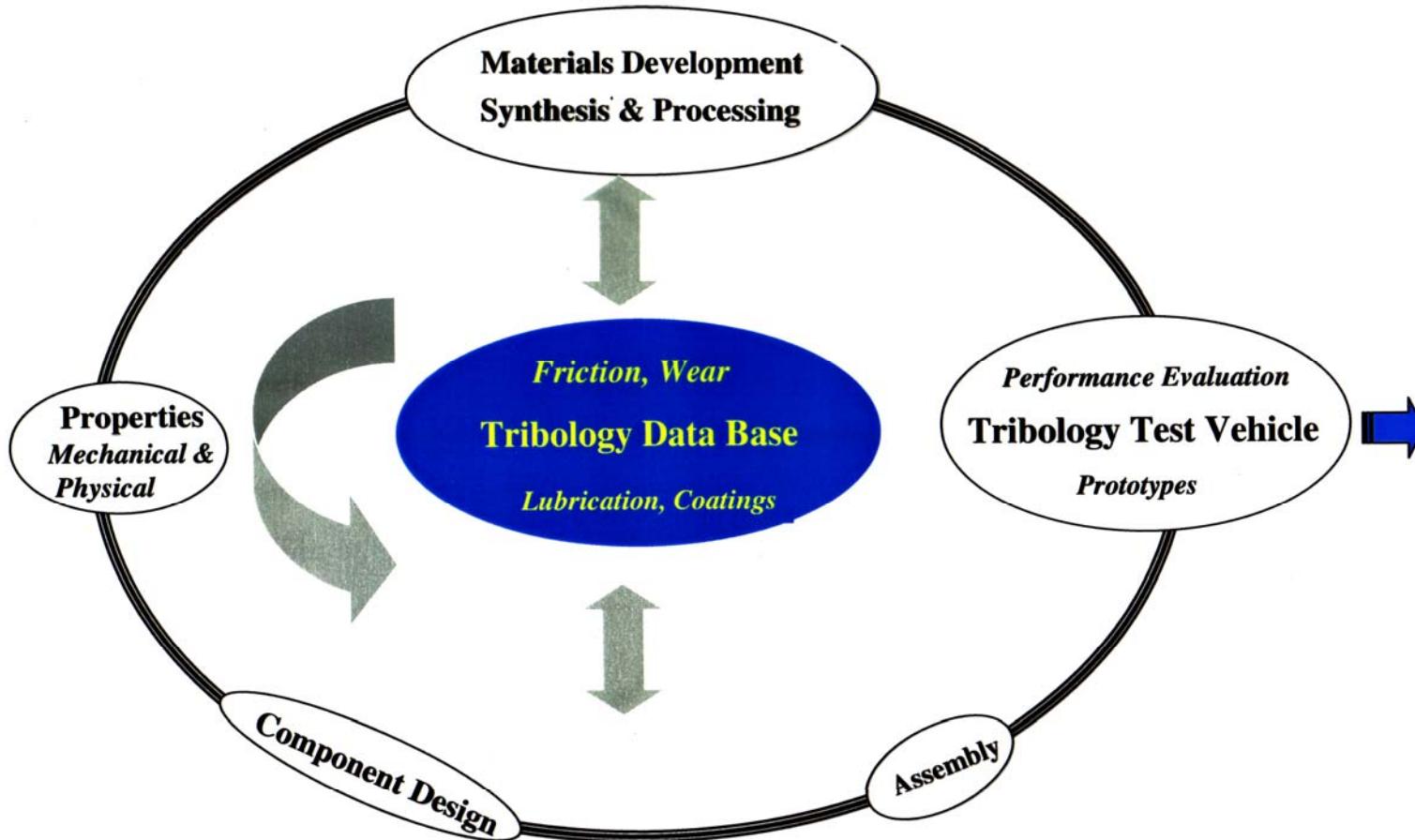
3. Hub interior aspect ratio ~100





# Concluding Thoughts: Systems Approach

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# Acknowledgements

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- MEMS
  - Mike Dugger
- PDCs
  - Rishi Raj (UC Boulder)
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  - Tom Scharf (Currently with University of North Texas)
  - John Jungk (Currently with Ball Aerospace)
- MMCs
  - Rajiv Asthana (University of Wisconsin-Stout)
  - Pradeep Rohatgi (University of Wisconsin-Milwaukee)